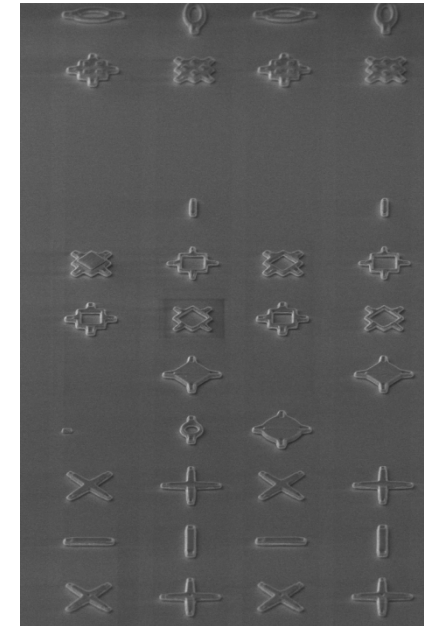
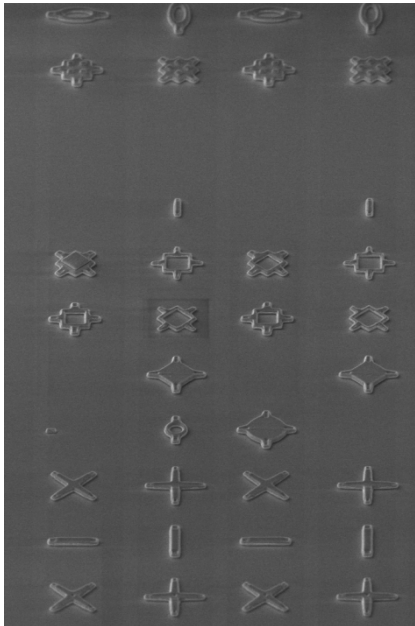


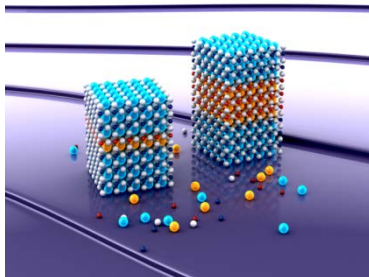
Making high quality freestanding magnon nanoresonators



G. Schmidt

*Institut für Physik & Center for materials science
Martin-Luther-Universität Halle Wittenberg
georg.schmidt@physik.uni-halle.de*

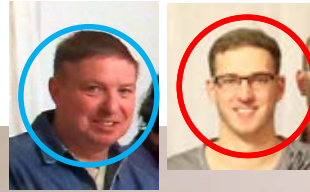
Financial support
EC funding: IP-IFOX
DFG: SFB 762



Contributors/Collaborators



■ Nanostructured
Materials



F. Heyroth, F. Syrowatka
(Center for Materials Science)
P. Trempler, P. Geyer, C. Hauser
(Nanostructured Materials)

G. Woltersdorf, R. Dreyer
(Optics Group)
S.G. Ebbinghaus
(Institute of Chemistry)

Overview



Nanostructured
Materials

Why YIG nanoresonators?

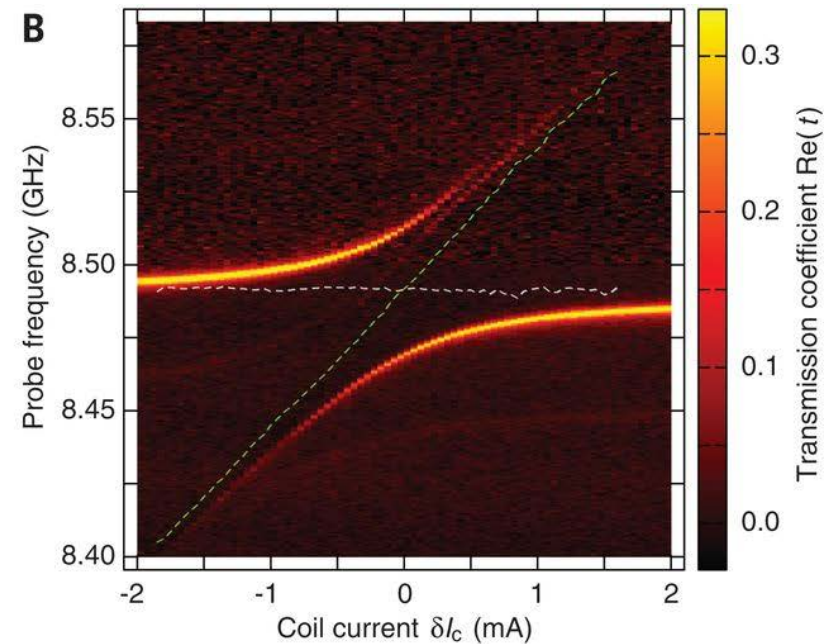
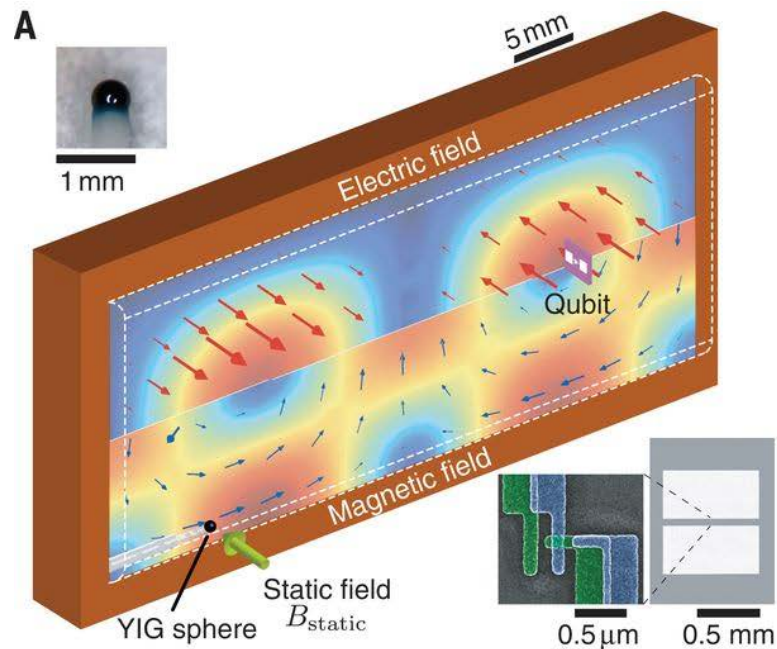
How to make them?

Structural properties

Magnonic properties

Quantum information processing

- Coupling of qubits to magnons successfully demonstrated
- Also promising: coupling of qubits to mechanical oscillators (by electric fields: Chu et al. Science **358**, 199 (2017))
- Why not use magnons and magnetoelastic coupling?



(Tabuchi et al. Science **349**, 405 (2015))

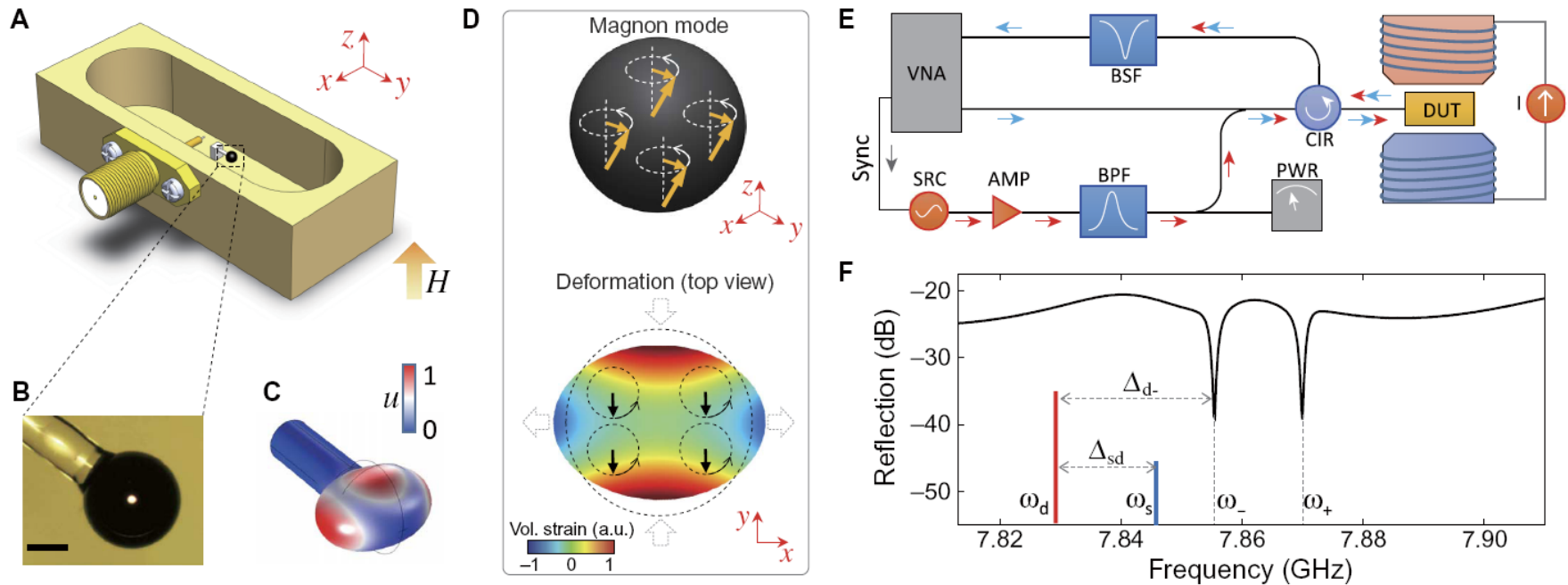
Magnonmechanics



Nanostructured
Materials

Magnons and Phonons

- Coupling of magnons and phonons recently demonstrated
- Drawback: YIG resonators are macroscopic spheres (250 μm) not suitable for integration



Zhang et al. Sci. Adv. 2016; 2 : e1501286

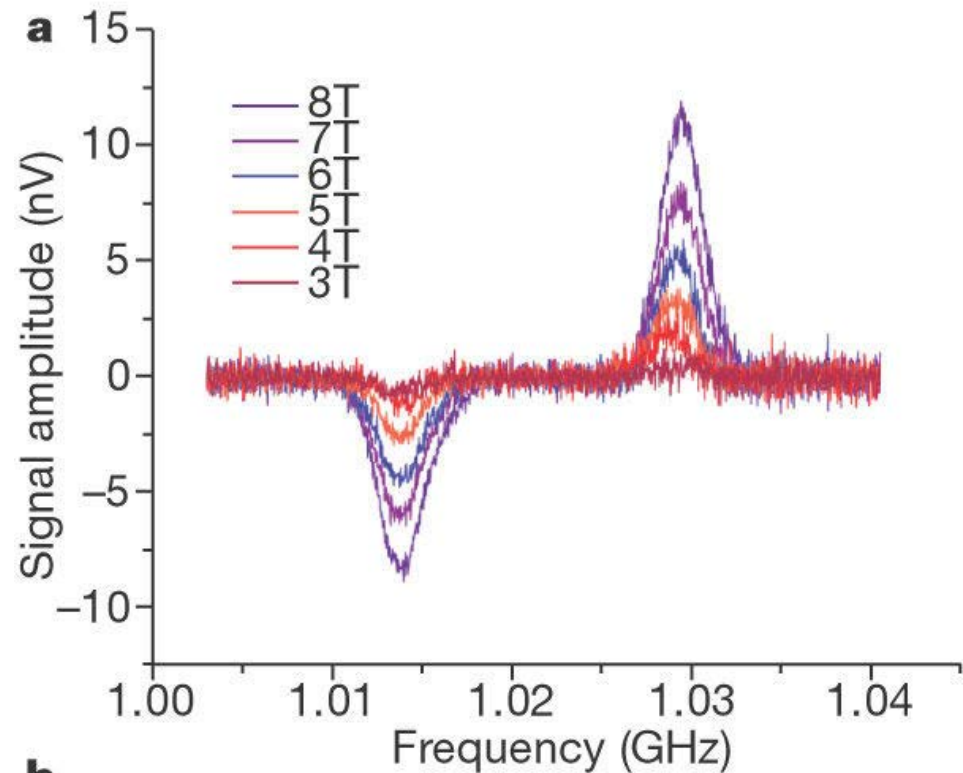
Overview



■ Nanostructured Materials

Can frequencies match?

- Demonstrated in 2003:
Mechanical nanoresonator with resonance frequency above 1 GHz
- Approaching range of useful magnon frequencies
- Example for YIG:
1 μm length, 150 nm thickness
 $f \sim 1$ GHz
- Typical shape:
cantilever (1 anchor point)
bridge (2 anchor points)
- How to make them?



Huang et al. Nature **421**, 496 (2003)

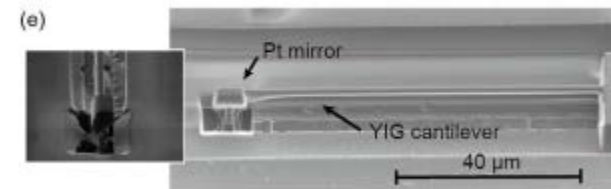
Making cantilevers and bridges



Nanostructured
Materials

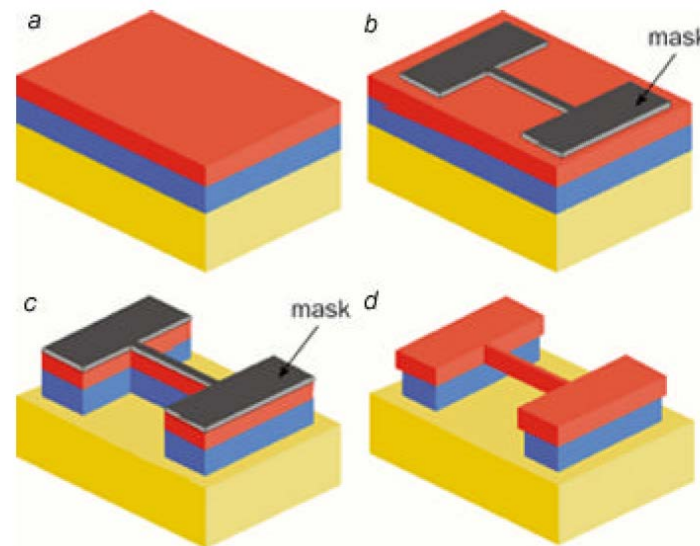
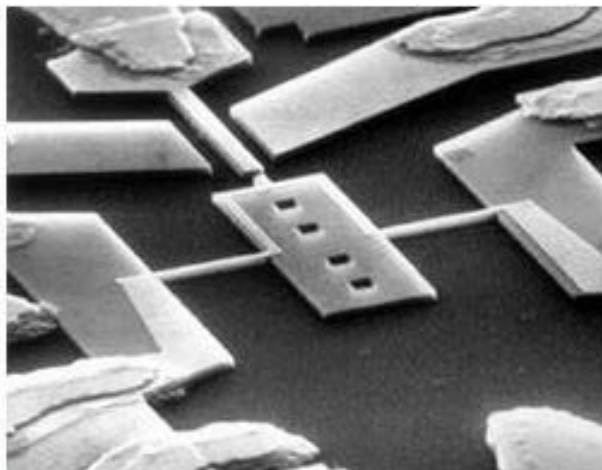
Crystalline materials

- Epitaxial growth at high temperatures
 - No patterning by resist and lift-off possible
- Use of sacrificial layers and wet etching
- Limited use of focused ion beam techniques



Seo et al. APL **110**
(2017)

M.L. Roukes
Physics World
(2001)

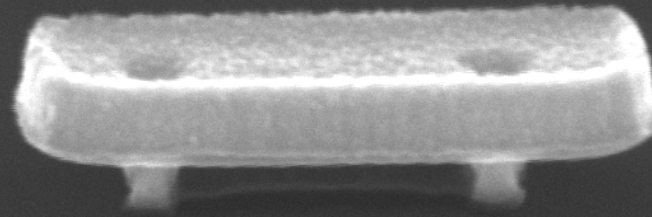


bridges

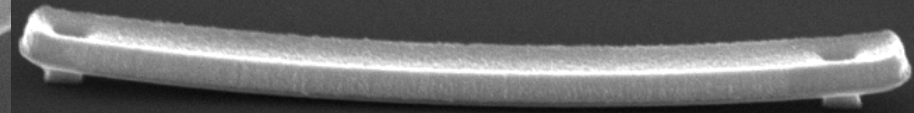
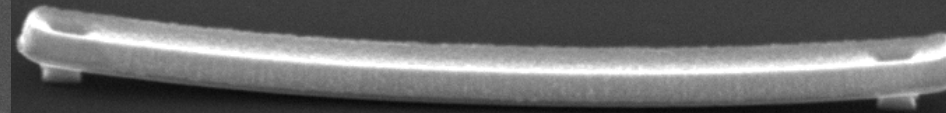
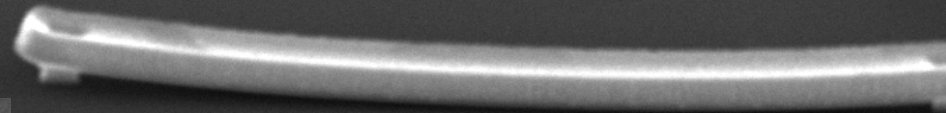


Nanostructured
Materials

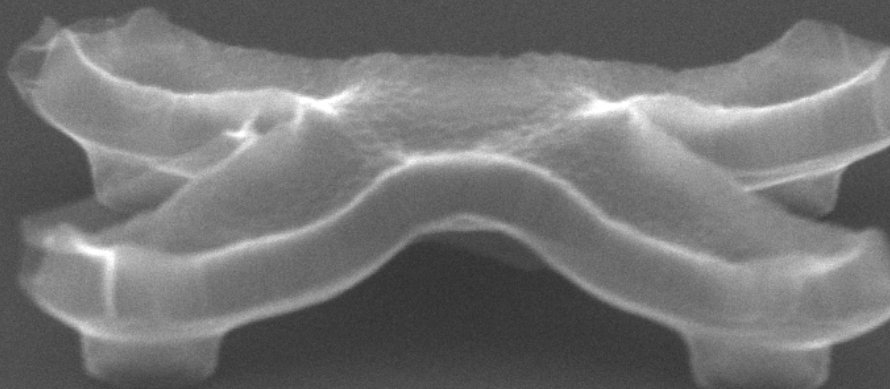
- Epitax
- N
- Use of
- Limite



Acc.V Spot Magn Det WD |
30.0 kV 2.0 39000x SE 11.4 bridges 30kV_



Acc.V Spot Magn Det WD | 2 μm
30.0 kV 2.0 14000x SE 14.6 30kV_4kV, 750/400



Acc.V Spot Magn Det WD | 500 nm
30.0 kV 1.2 40000x SE 11.4 two-level bridges

Making cantilevers and bridges



Nanostructured
Materials

Crystalline materials

- Epitaxial growth at high temperatures
 - No patterning by resist and lift-off possible
- Use of sacrificial layers and wet etching
- Limited use of focused ion beam techniques

Amorphous/polycrystalline

- Patterning by lift off
 - Use multilayer resists with different sensitivity
 - Use different acceleration voltages

No sacrificial layers for YIG/GGG!!!

Deposition by LPE or PLD at high temperatures forbids resist-based lift-off!!!

How to combine Lift-Off with crystalline YIG???

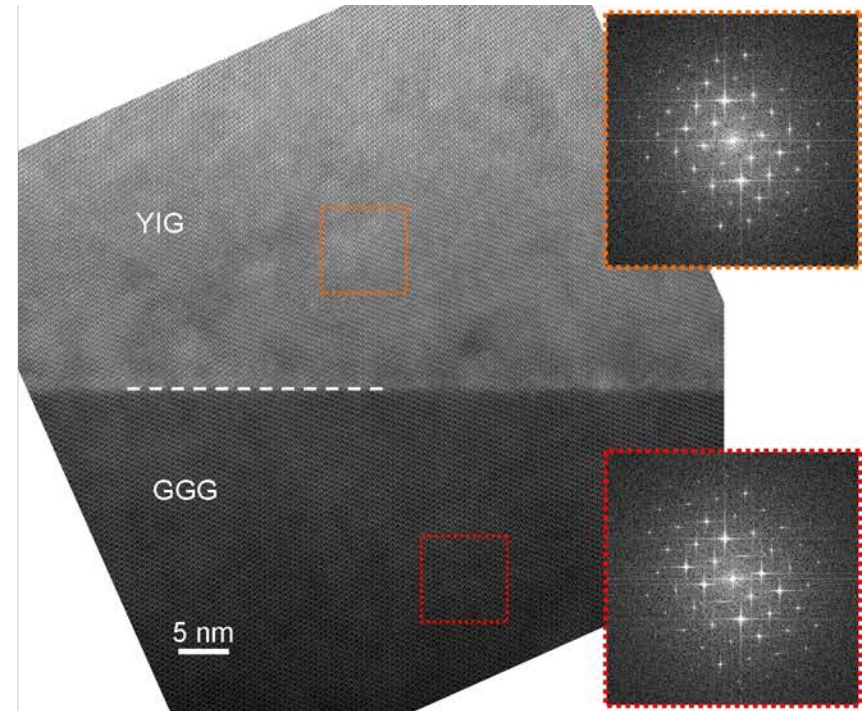
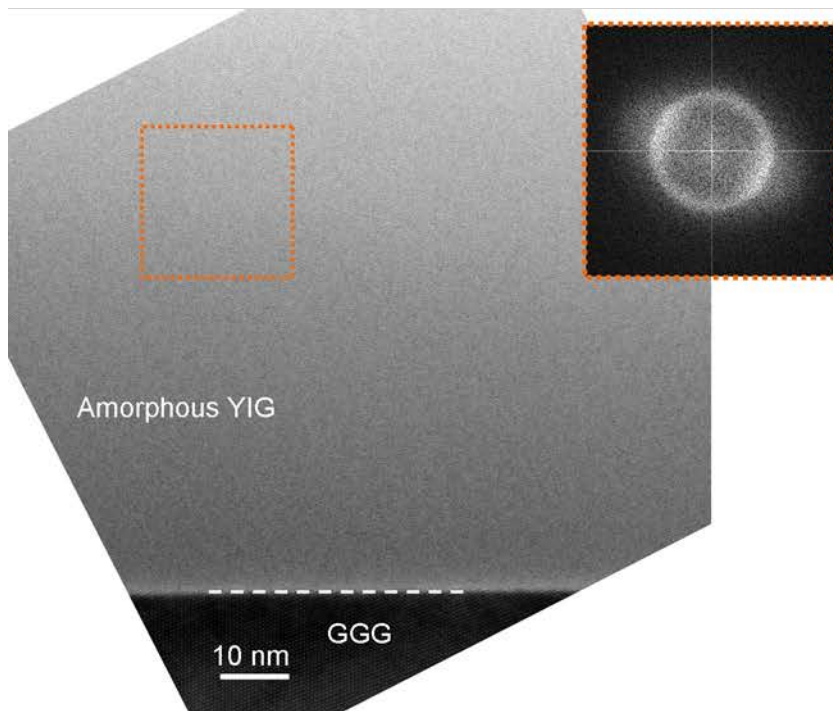
Breakthrough



Nanostructured
Materials

YIG deposition by PLD at RT

- Amorphous YIG deposited at RT
- Annealing leads to high quality material
- Perfect crystallization over at least 100 nm
- Substrate acts as seed.



(C. Hauser, GS et al. Scientific Reports **6**, 20827 (2016))

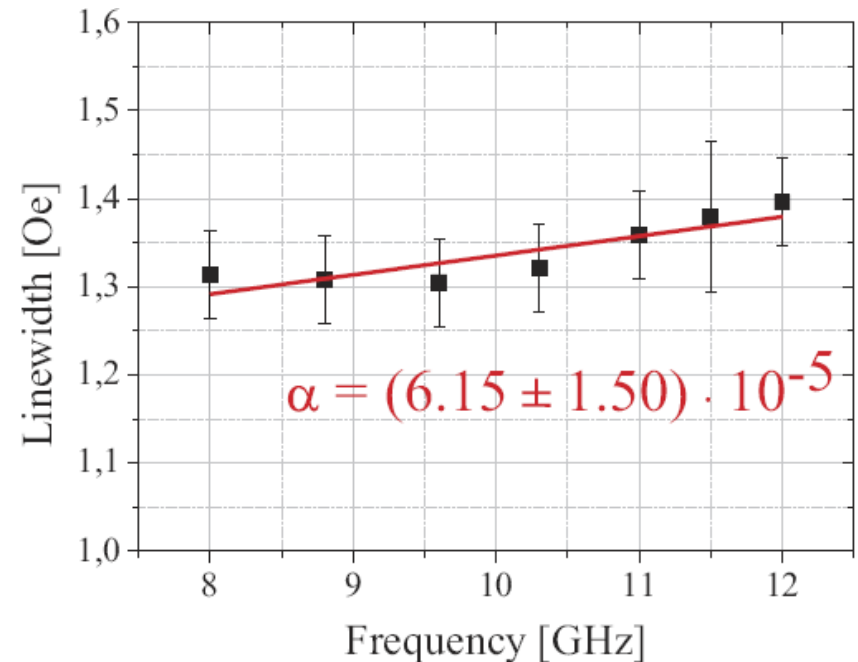
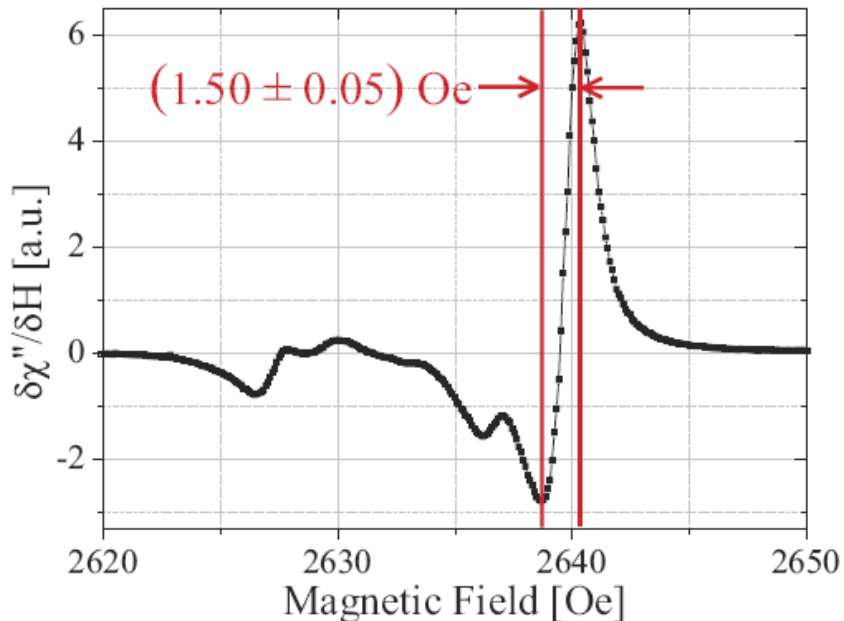
Breakthrough



Nanostructured
Materials

YIG deposition by PLD at RT

- Annealed material has very low damping
- For a 56 nm thick layer:
 - Linewidth of 0.13 mT @ 9.6 GHz
 - Damping $\alpha=6.15 \times 10^{-5}$

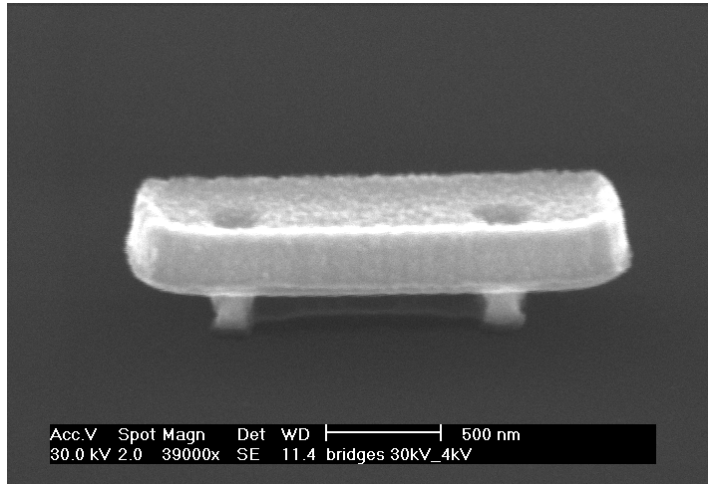


Breakthrough

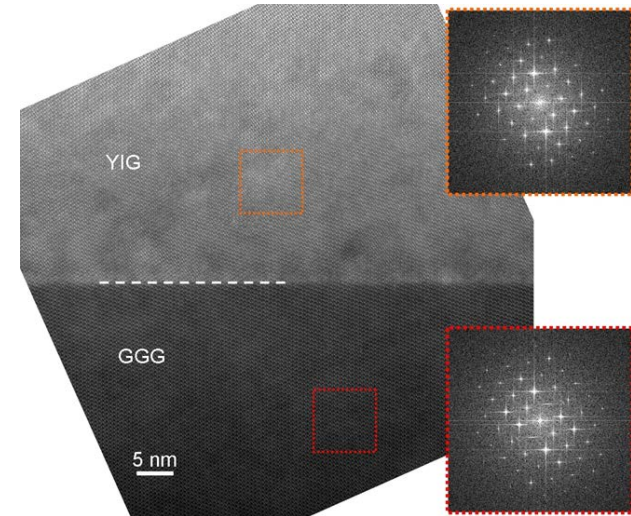


Nanostructured
Materials

Combine the two



+



– Big questions:

Are PLD and 3D lift-off compatible?

Can the crystallization propagate from the substrate through the resonator?

Is the magnonic quality still good?

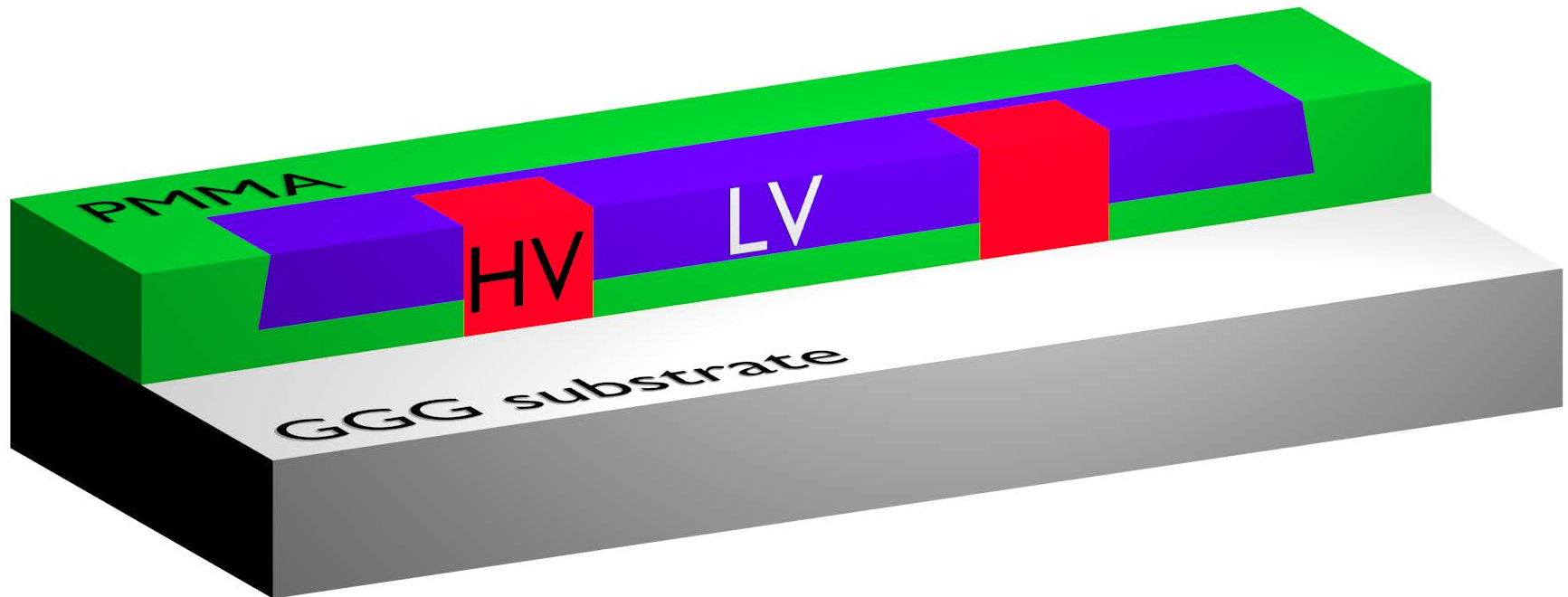
Process



Nanostructured
Materials

Multi-voltage electron beam exposure

- Exposure with different penetration depth defines profile:
HV for posts, LV for span



(F. Heyroth, GS et al. cond-mat.1802.03176)

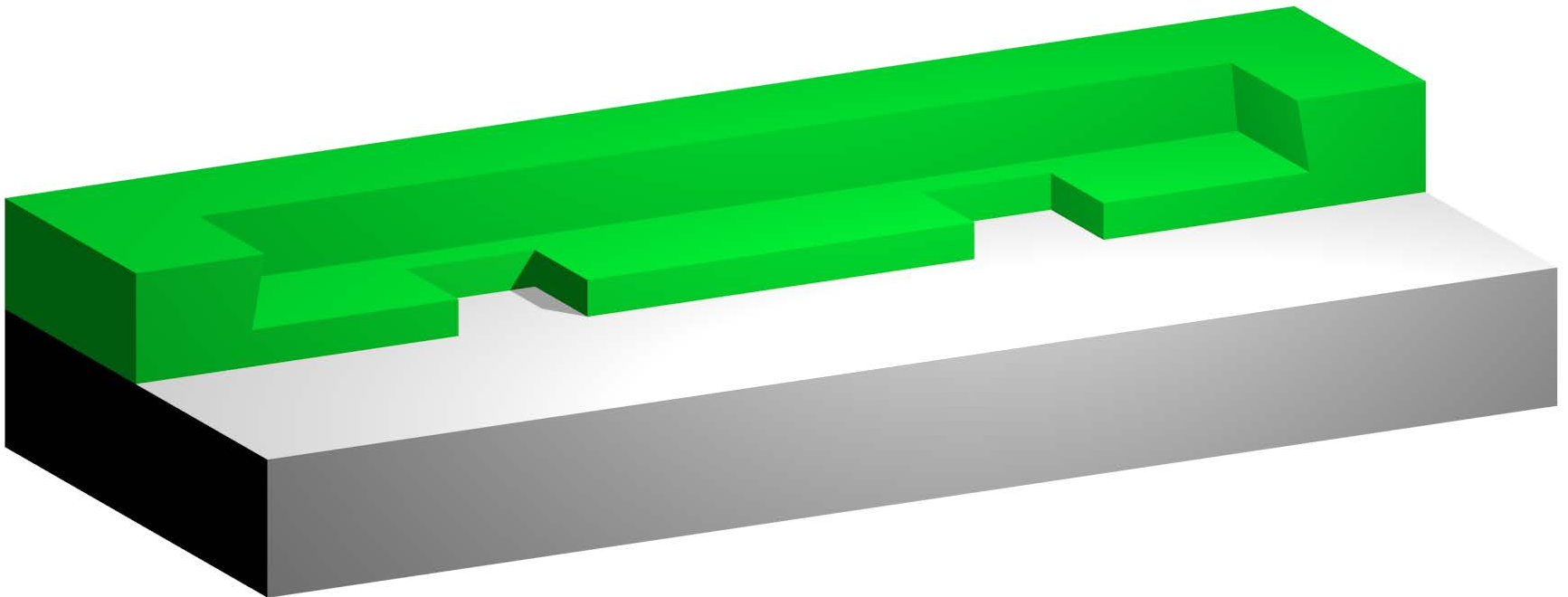
Process



Nanostructured
Materials

Development

- Results in slight undercut suitable for lift-off



(F. Heyroth, GS et al. cond-mat.1802.03176)

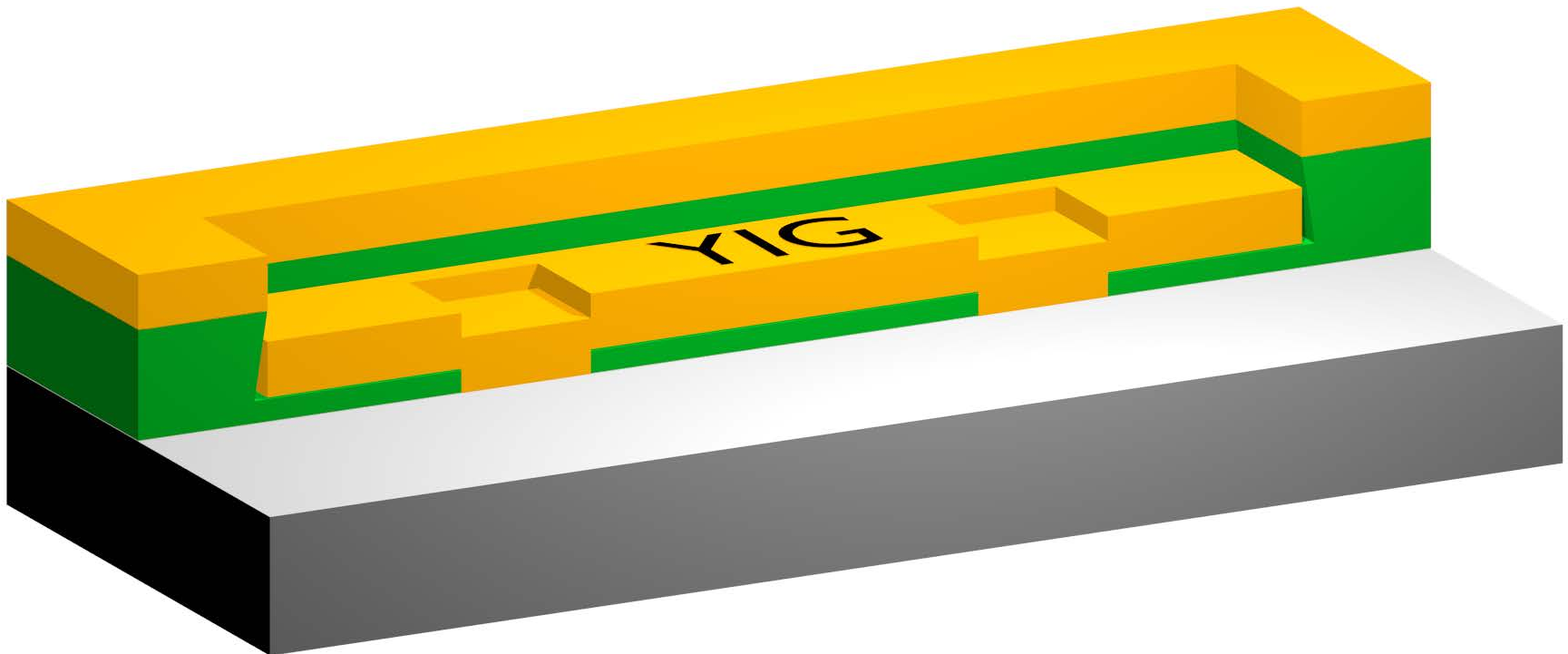
Process



Nanostructured
Materials

Pulsed laser deposition

- Directed deposition (beam-like) separates top layer from bridge (more critical than for 2D structures)



(F. Heyroth, GS et al. cond-mat.1802.03176)

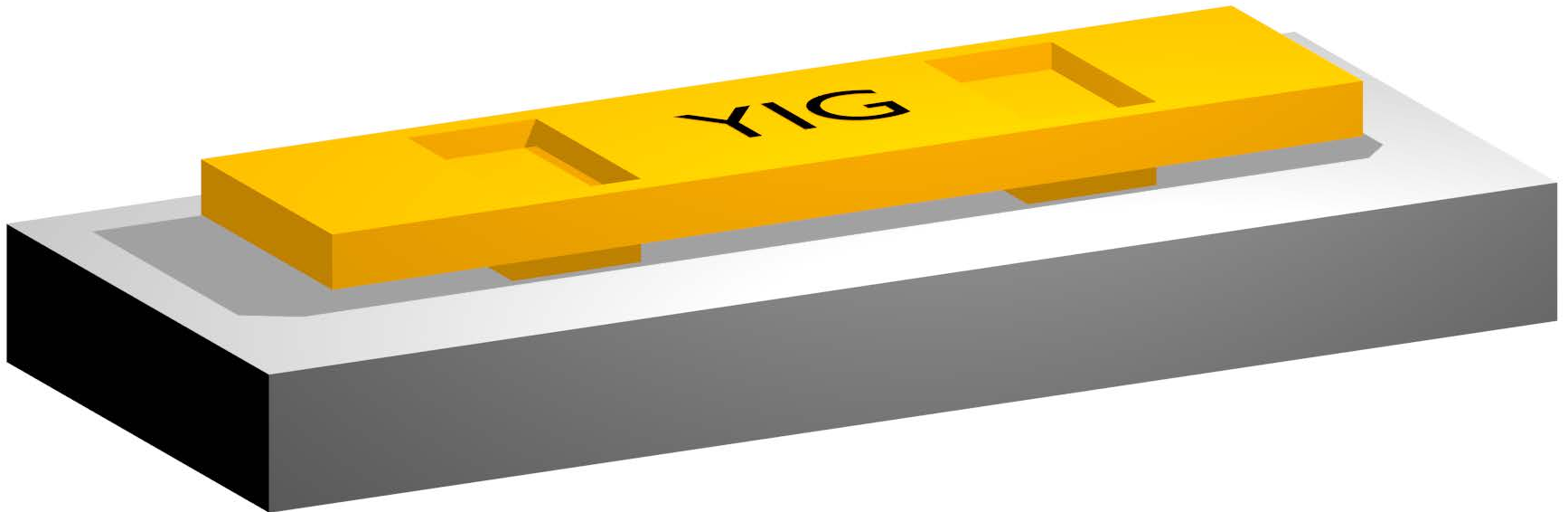
Process



Nanostructured
Materials

Lift-off

- Top layer is removed, bridge remains (ideally)



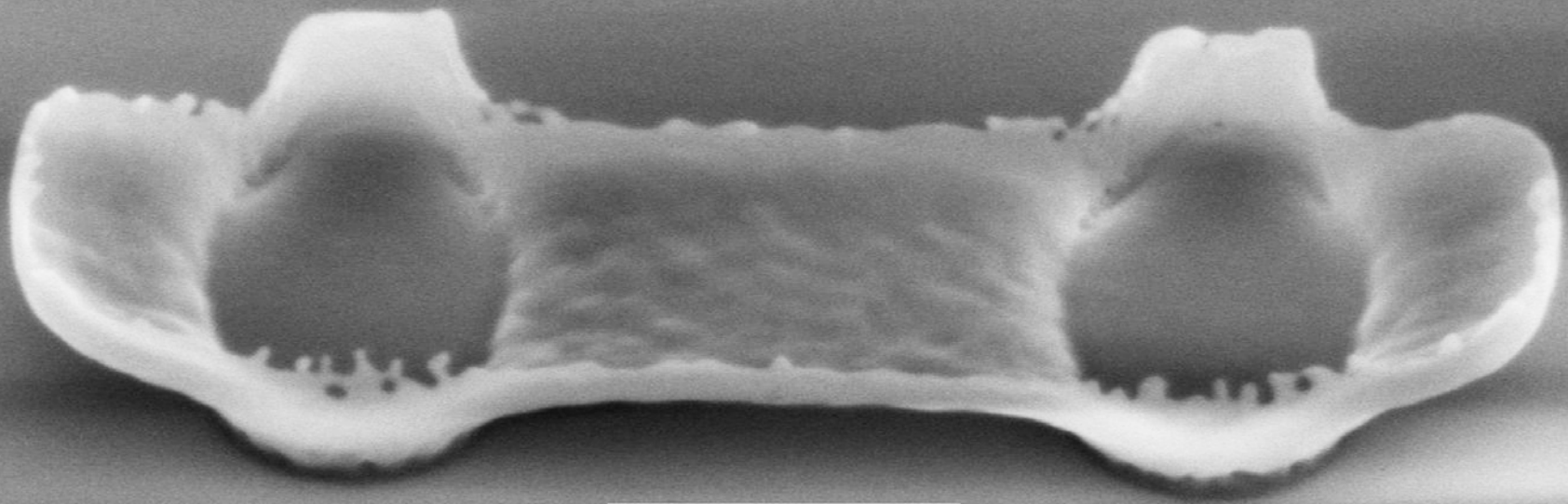
(F. Heyroth, GS et al. cond-mat.1802.03176)

Results



Nanostructured
Materials

Yeah! Bridges!



g

500 nm

(F. Heyroth, GS et al. cond-mat.1802.03176)

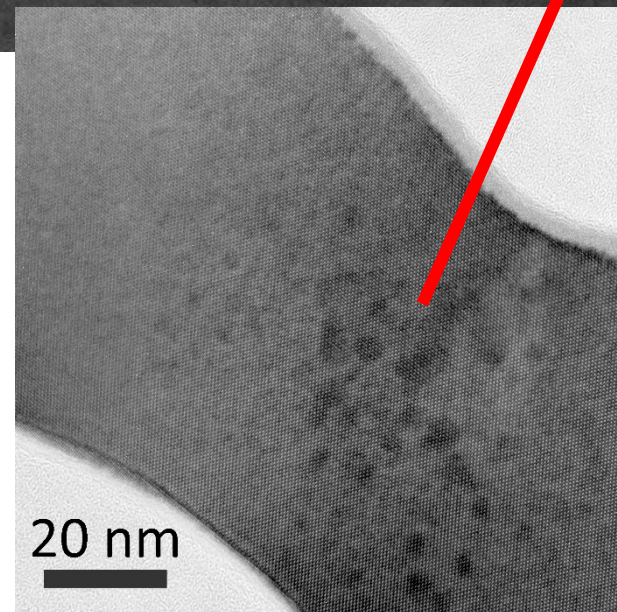
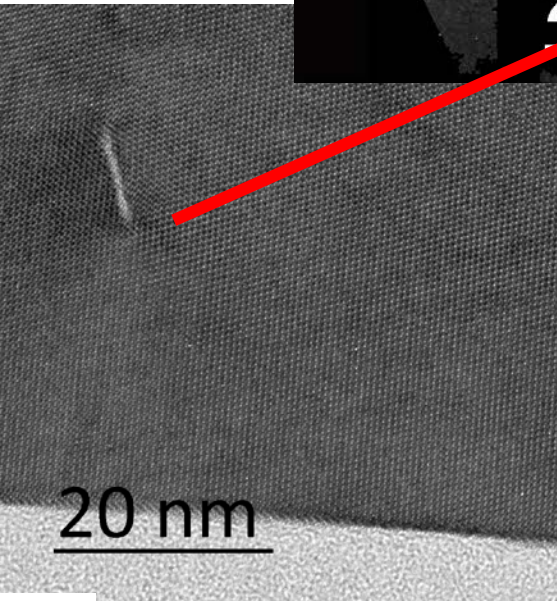
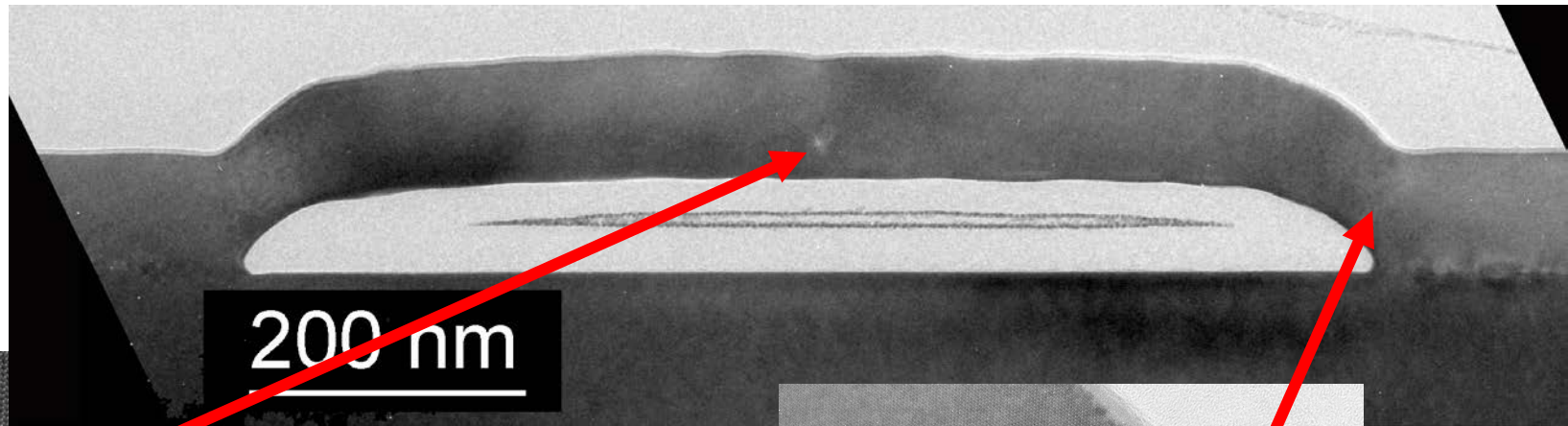
Transmission electron microscopy



Nanostructured
Materials

Monocrystalline span (almost)

- Crystallization fronts propagate from the substrate, single defect at center of span
- Transition from post to span shows accumulation of defects



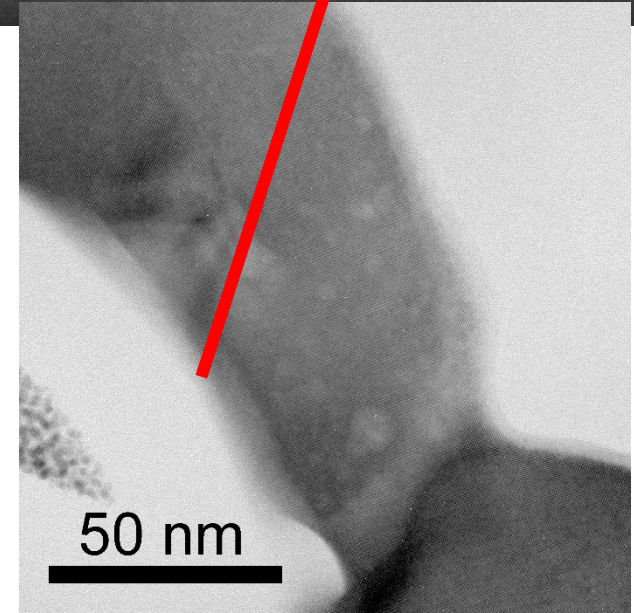
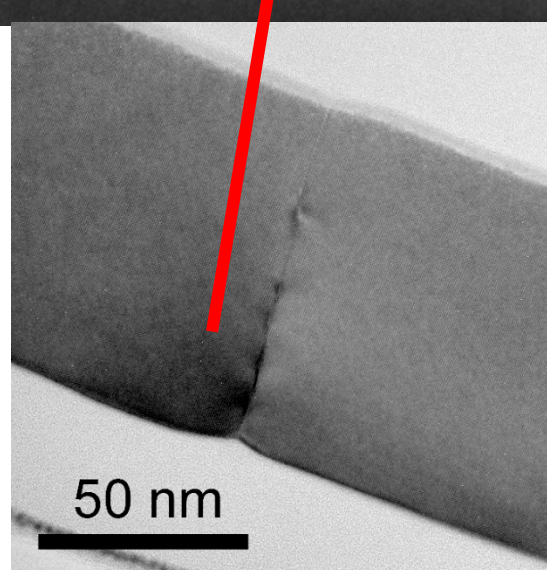
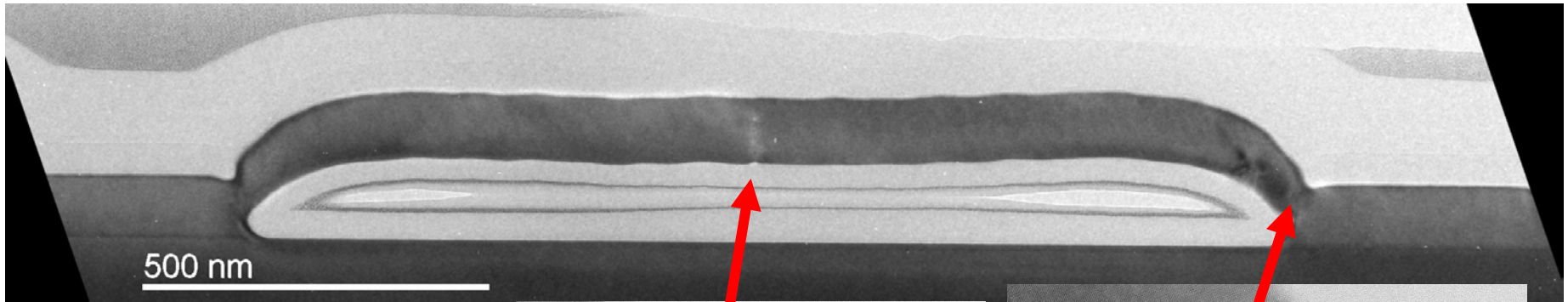
Transmission electron microscopy



Nanostructured
Materials

Higher bridges

- 200 nm high bridge shows increased strain
- Larger defect at center
- More defects at post



(F. Heyroth, GS et al.
cond-mat.1802.03176)

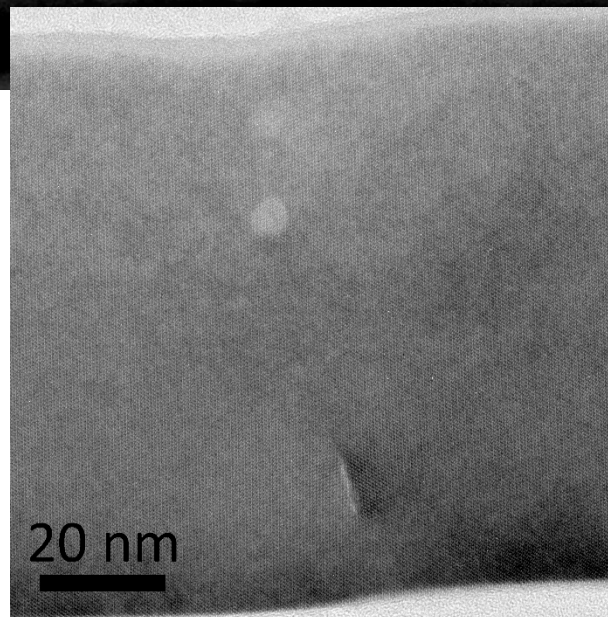
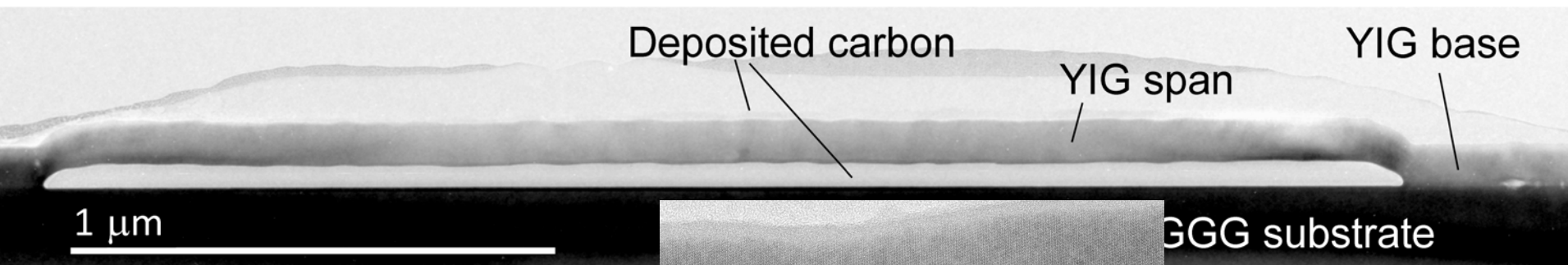
Transmission electron microscopy



Nanostructured
Materials

Longer bridges

- Bridges of several micron length are possible
- Still defect in span only at center
- No visible bending due to strain (all images after annealing)



(F. Heyroth, GS et al.
cond-mat.1802.03176)

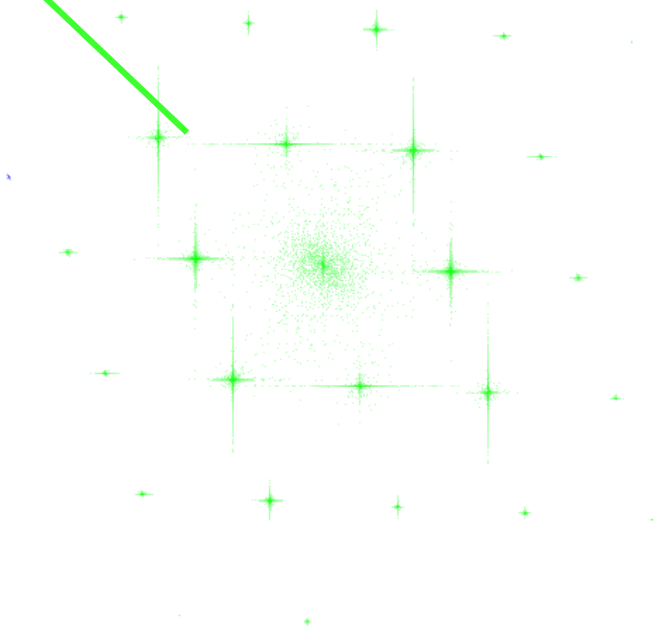
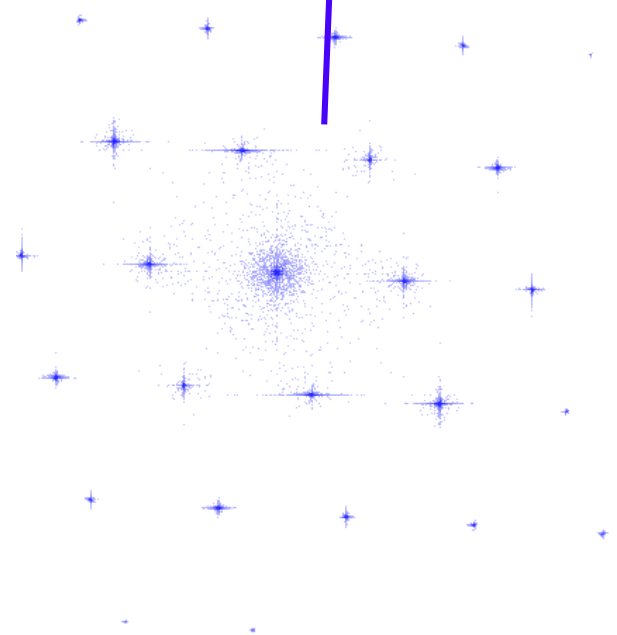
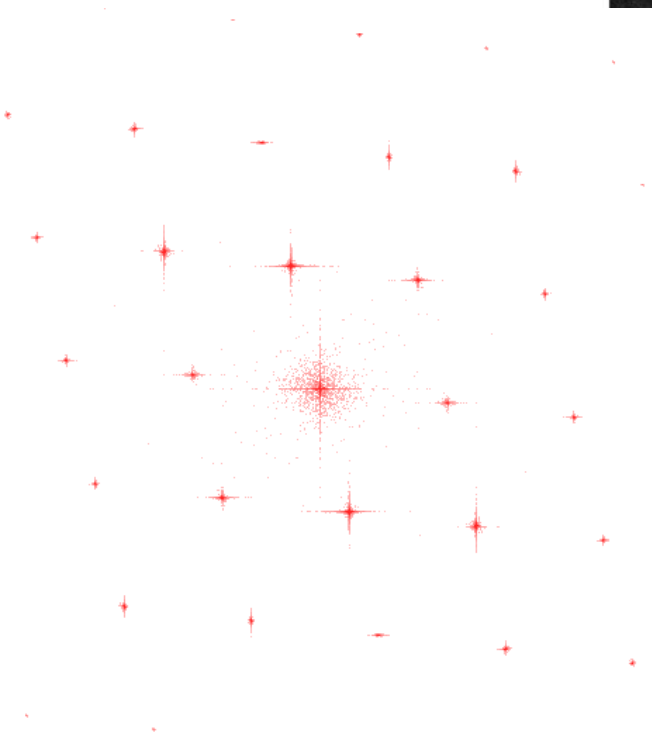
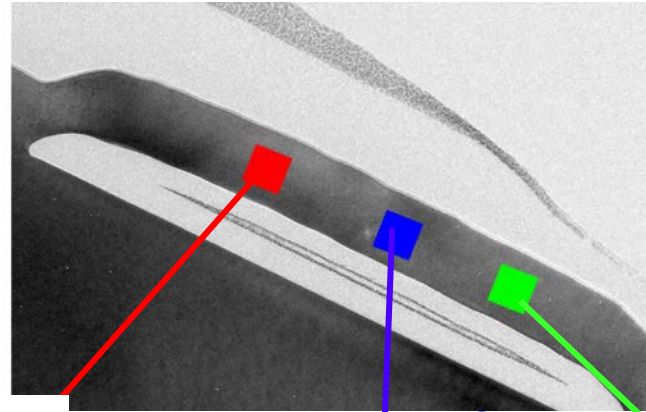
Lattice tilt?

FFT

- Image different areas on the bridge
- Make FFT of lattice



Nanostructured
Materials



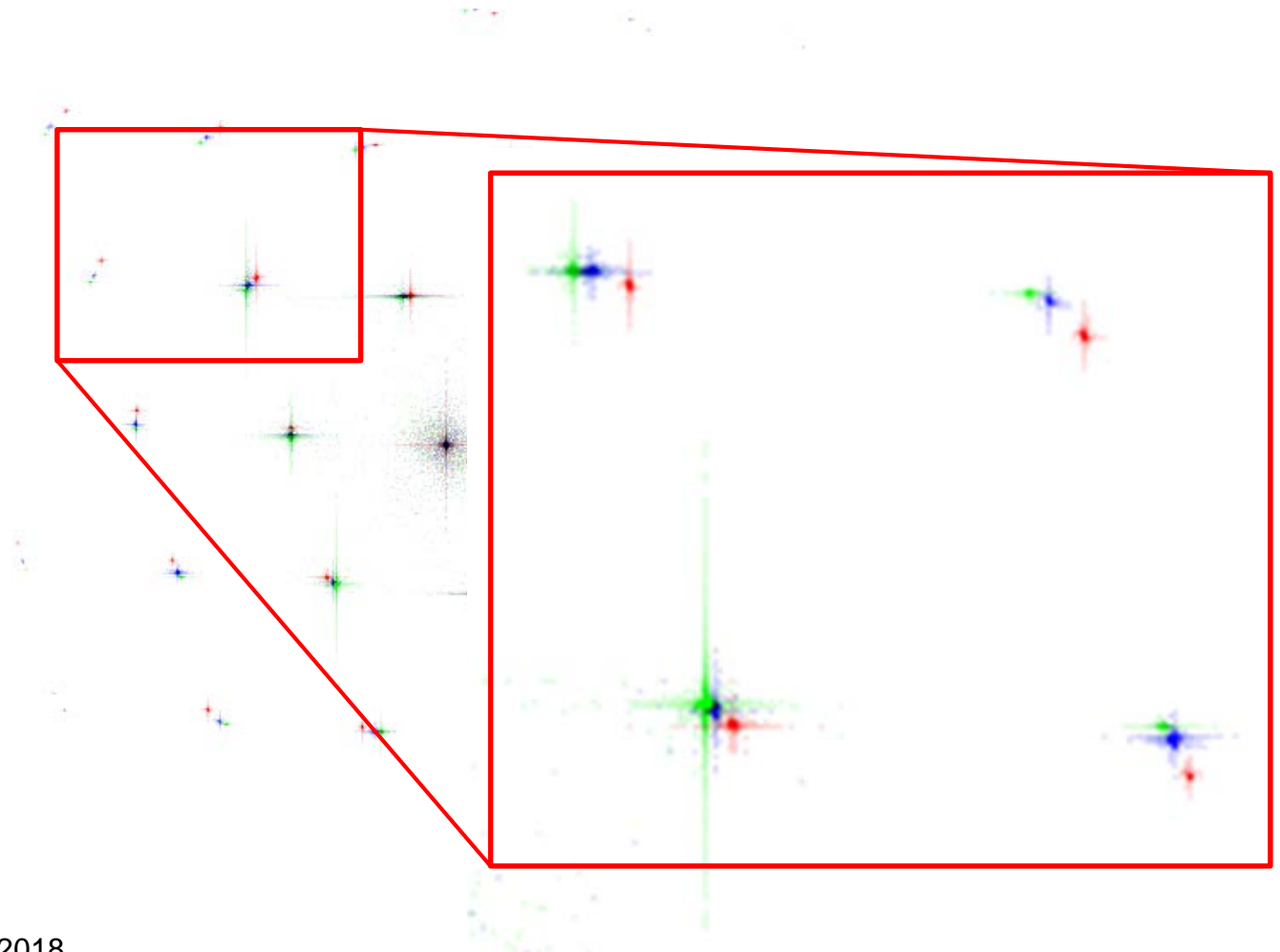
Lattice tilt?

Superposition

- Superposition shows small rotation (between 0.5 and 3°)
- Rotation between left and right side of the bridge (obviously also between side of the span and substrate)



Nanostructured
Materials



(F. Heyroth, GS et al.
cond-mat.1802.03176)

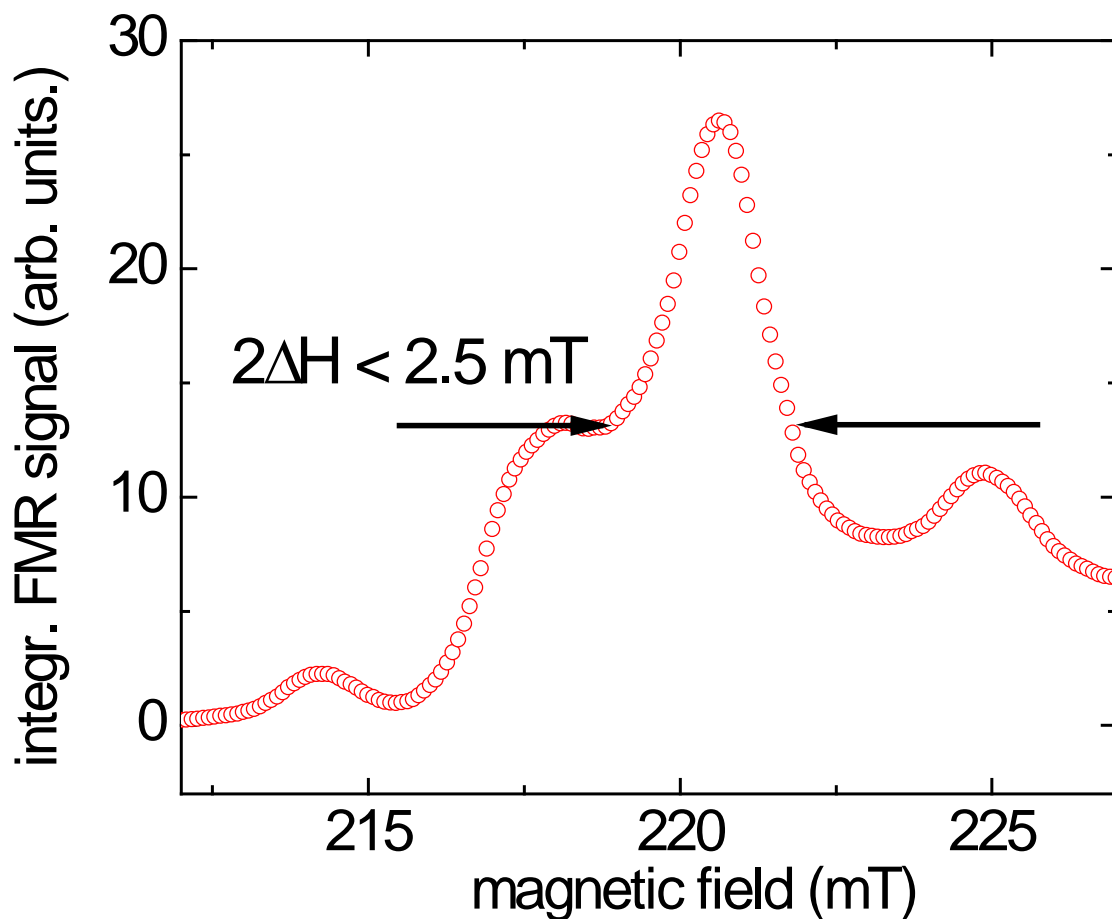
Ferromagnetic resonance



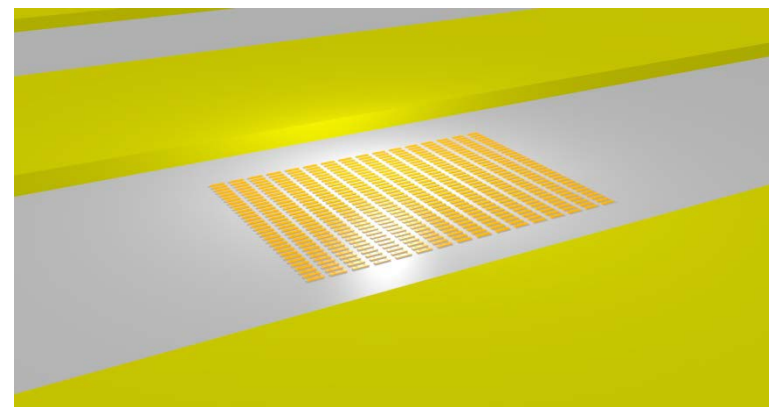
Nanostructured
Materials

Array of bridges

- Measurement on 8000 (nominally) identical bridges (3000x500 nm)
- Linewidth of main resonance $\Delta H = 1.25$ mT @ 8 GHz
- Either very similar bridges or very narrow lines



(F. Heyroth, GS et al.
cond-mat.1802.03176)



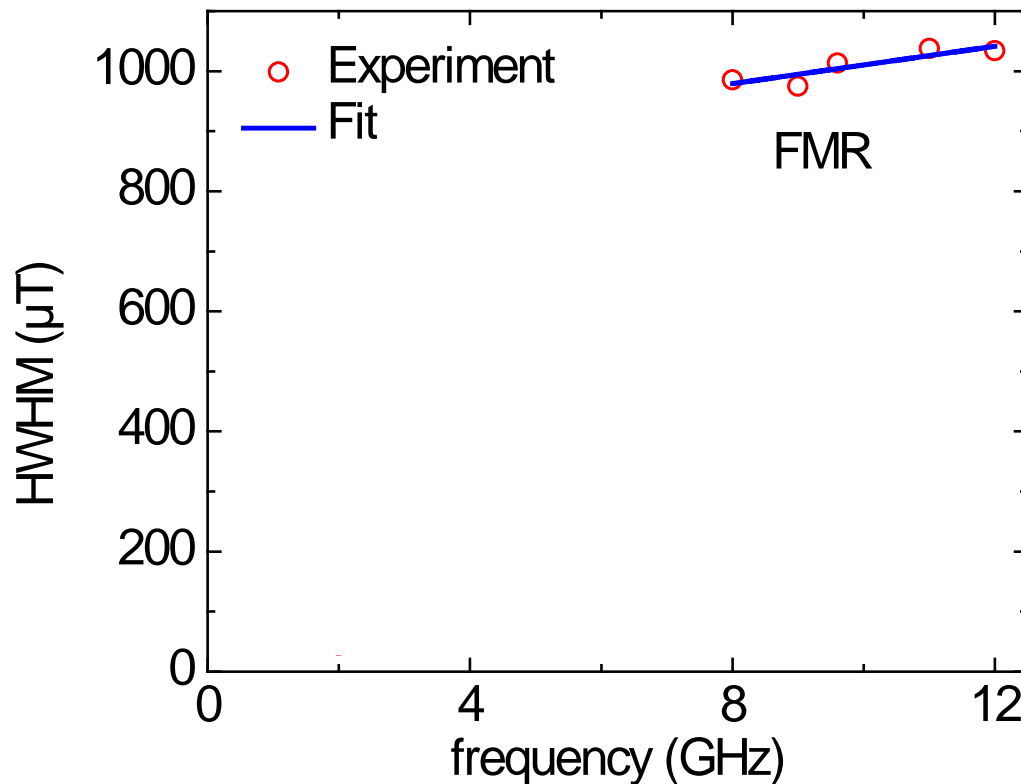
Ferromagnetic resonance



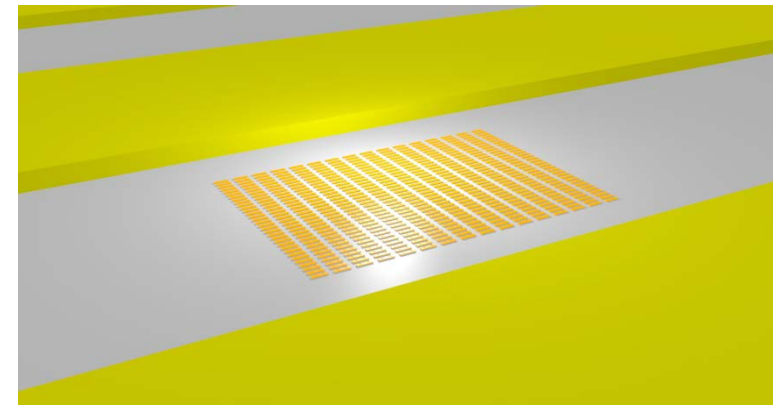
Nanostructured
Materials

Damping

- Measurements at various frequencies
- At low frequencies lines cannot be resolved
- Measurements between 8 and 12 GHz indicate Damping $\alpha \leq 4.1 \times 10^{-4}$



(F. Heyroth, GS et al.
cond-mat.1802.03176)



TR-MOKE

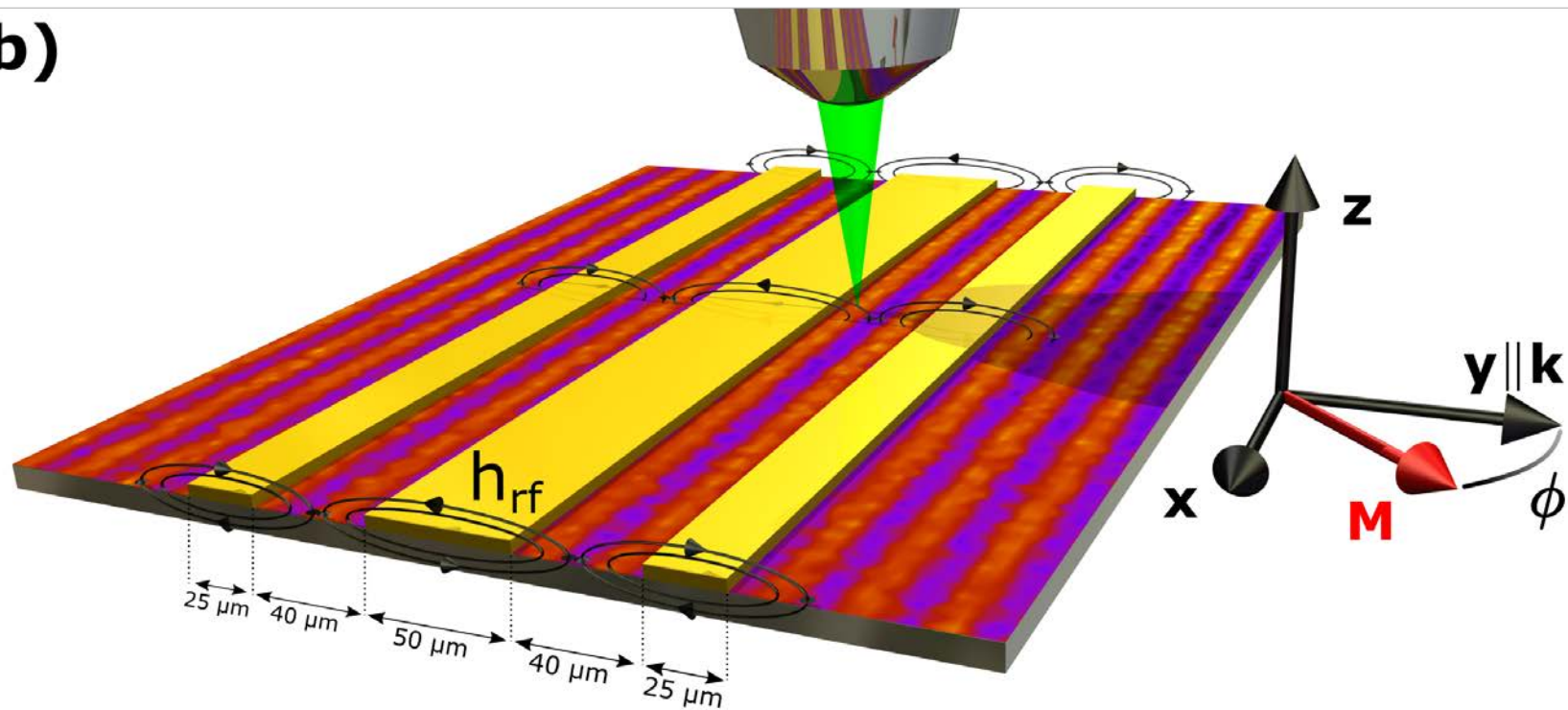


Nanostructured
Materials

Time resolved scanning Kerr microscopy

- Allows to locally visualize time development of x or y-component of magnetization vector
- Resolution: ~ 300 nm
- Time resolution ~ 1 ps

b)



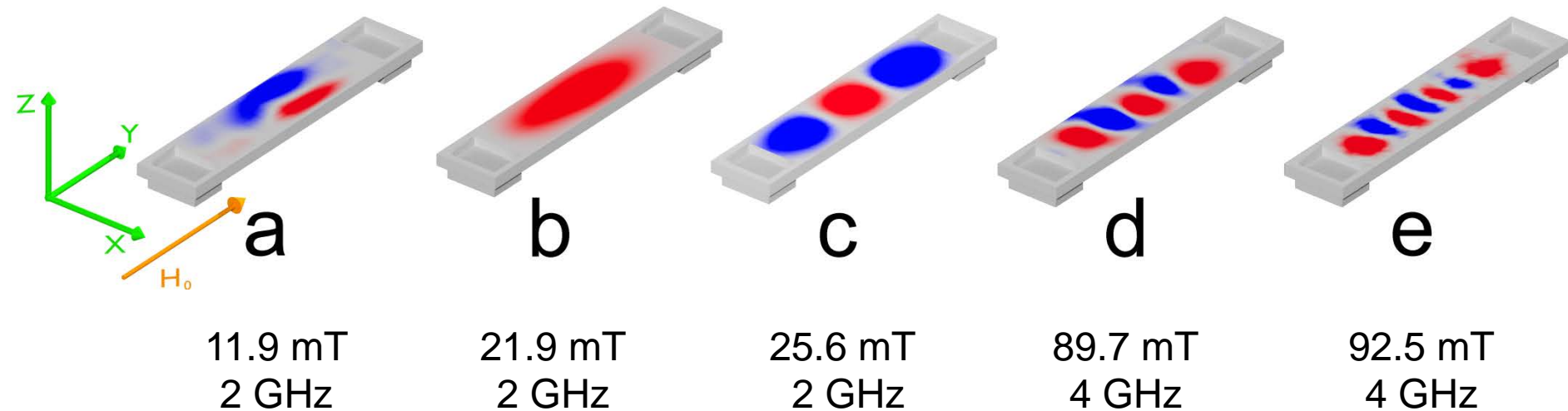
TR-MOKE



Nanostructured
Materials

Standing spin waves

- Homogeneous mode (zero nodes)
- Damon Eshbach mode at lower fields (as expected)
- Backward volume modes at higher fields (up to 6 nodes)



(F. Heyroth, GS et al. cond-mat.1802.03176)

Simulation

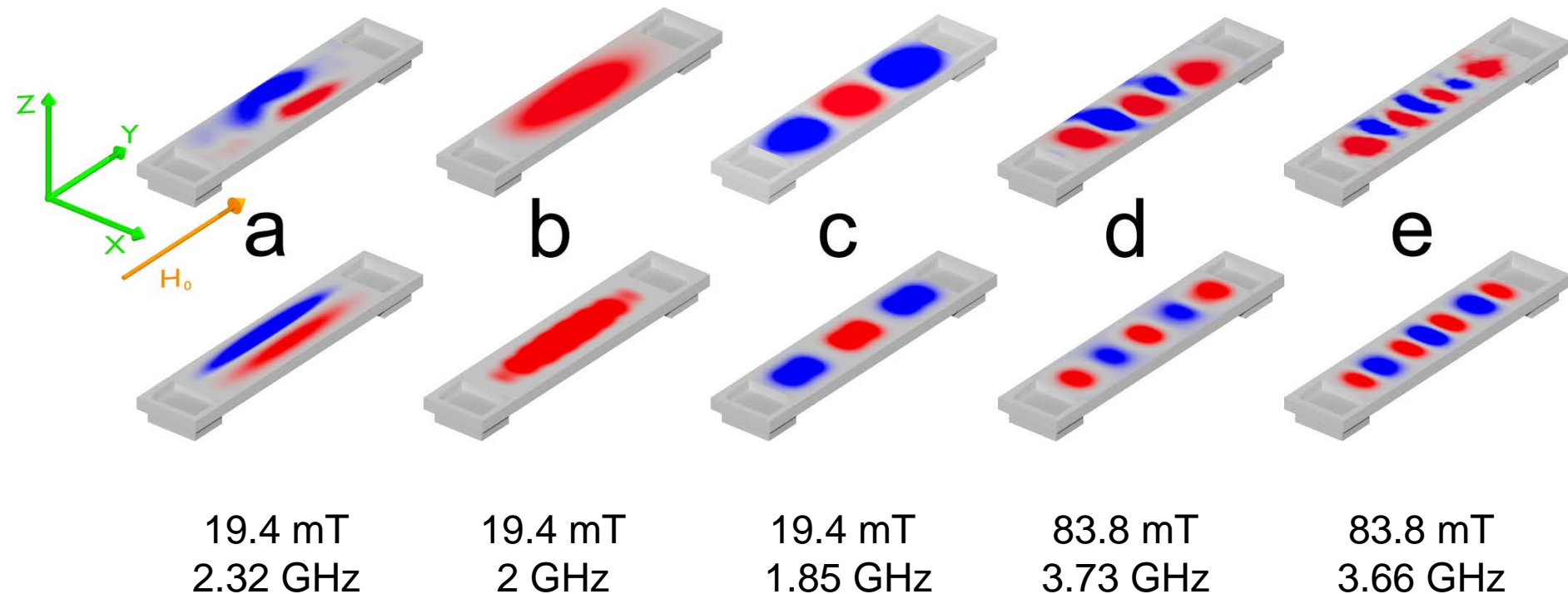


Nanostructured
Materials

Spin dynamics simulation using mumax 3*

- Single step excitation
- FFT for each point of the bridge
- Select frequency
- Reconstruct image from amplitude and phase

*"The design and verification of mumax3", AIP Advances 4, 107133 (2014).



(F. Heyroth, GS et al. cond-mat.1802.03176)

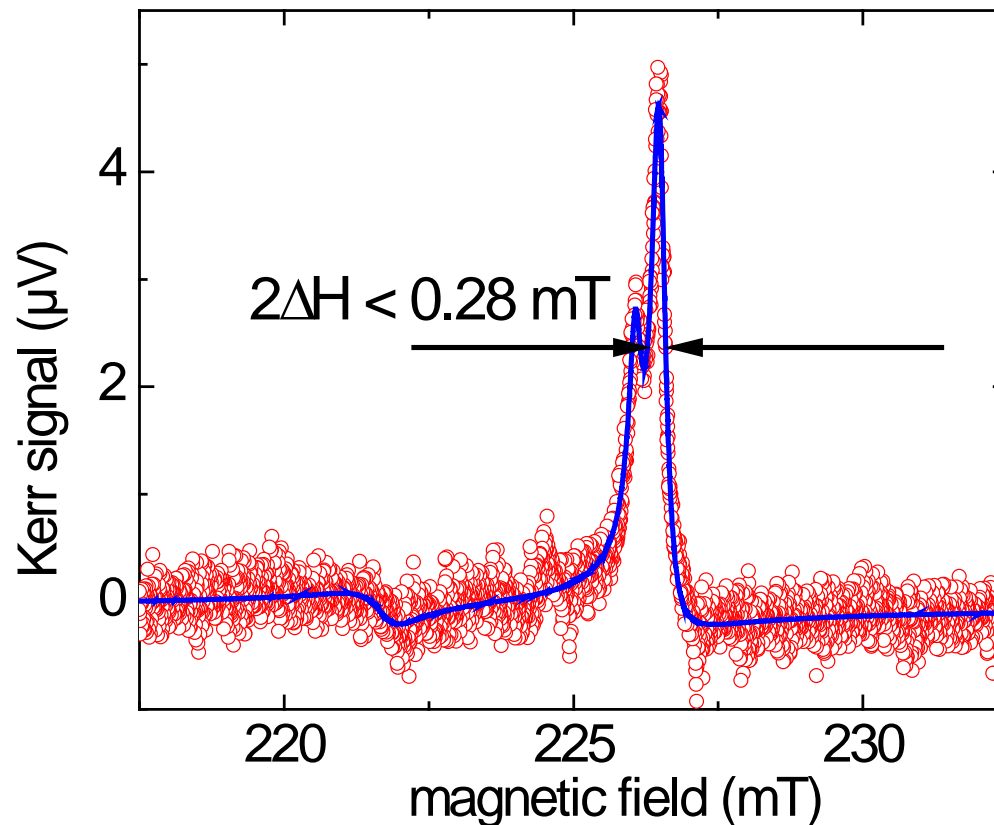
Scanning TR MOKE

Ferromagnetic resonance

- FMR on single spot on single bridge
- Linewidth of main resonance $\Delta H = 140 \mu\text{T} @ 8\text{GHz}$
- Corresponds to high quality thin film material
- Much more narrow than for array: Possible reasons?



Nanostructured
Materials



(F. Heyroth, GS et al.
cond-mat.1802.03176)

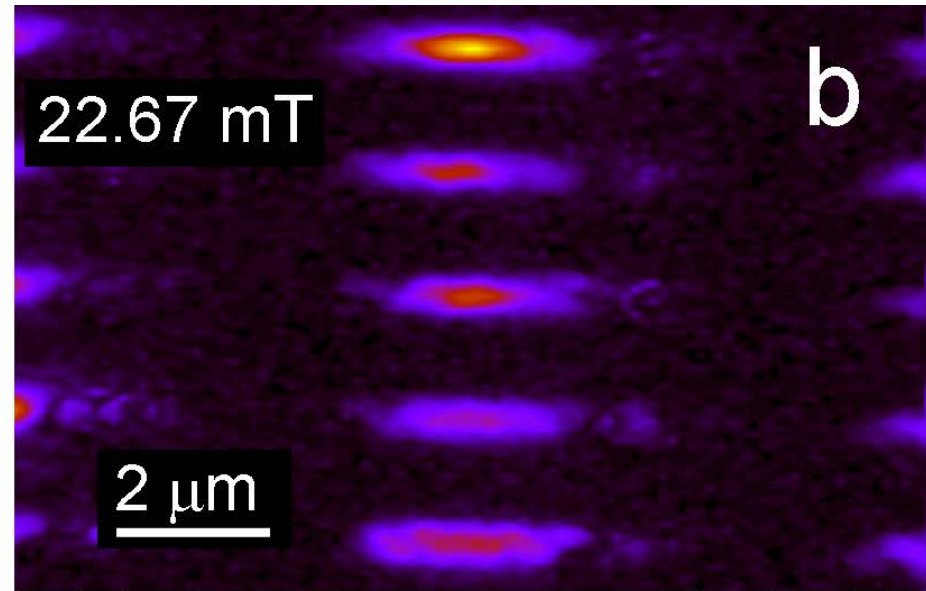
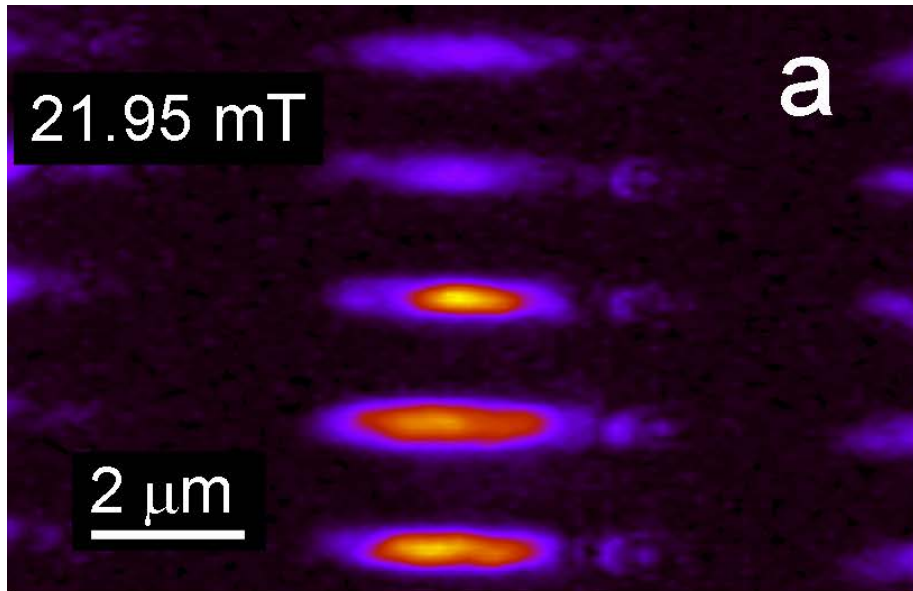
Scanning TR MOKE



Nanostructured
Materials

Different bridges?

- Main resonance on different bridges may at least vary by 0.7 mT @ 2 GHz
- May explain the broadening in the array at 8 GHz (1.4 mT)



(F. Heyroth, GS et al. cond-mat.1802.03176)

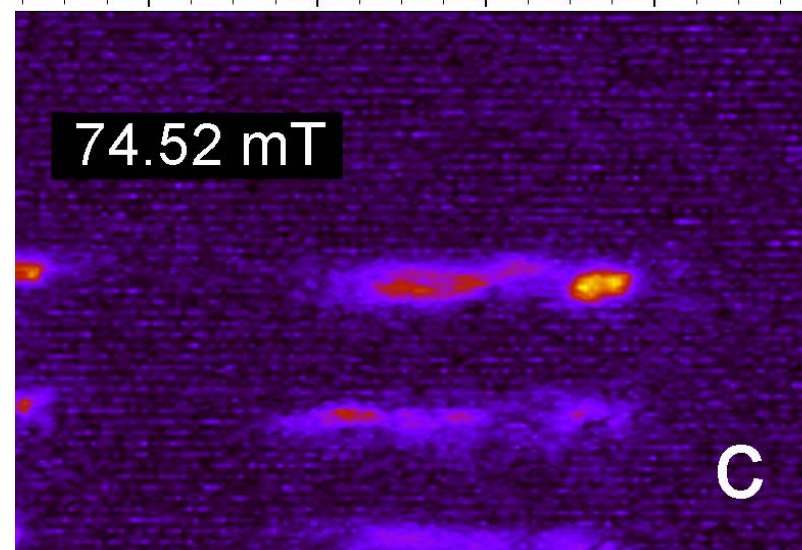
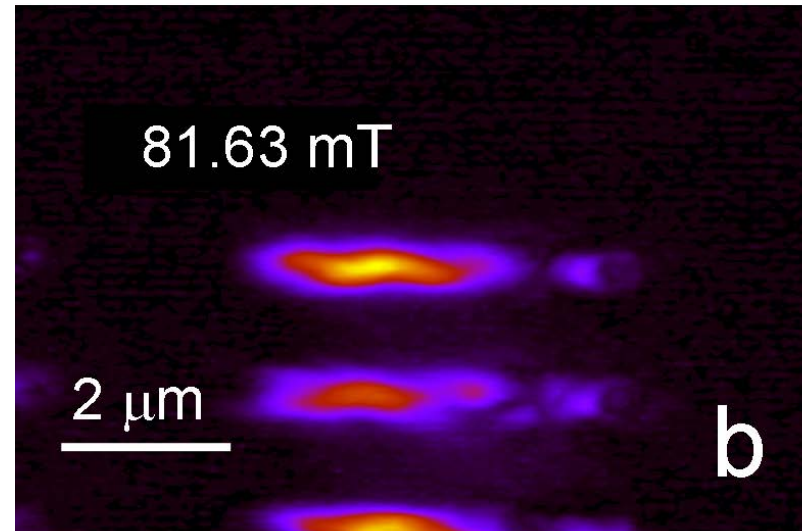
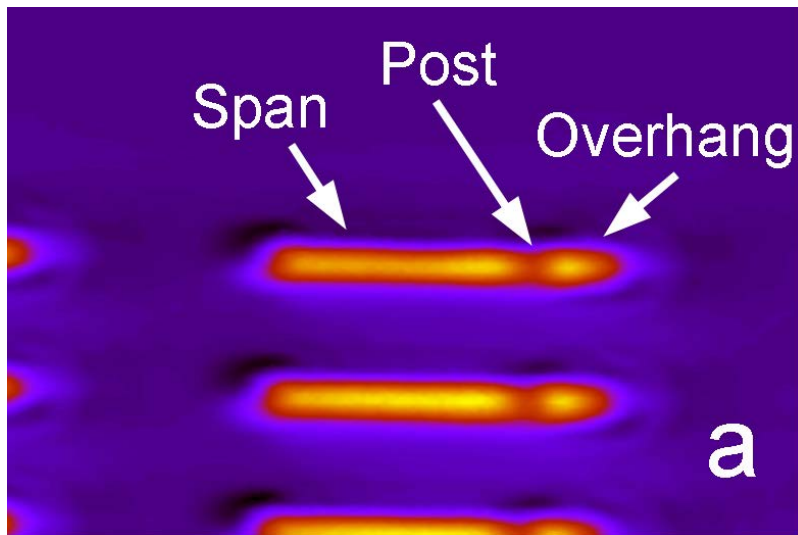
Scanning TR MOKE



Nanostructured
Materials

Different parts (span/post)?

- Resonance of span and overhang differ by 7 mT
- Much more than broadening of array
- Leads to additional peak



(F. Heyroth, GS et al. cond-mat.1802.03176)

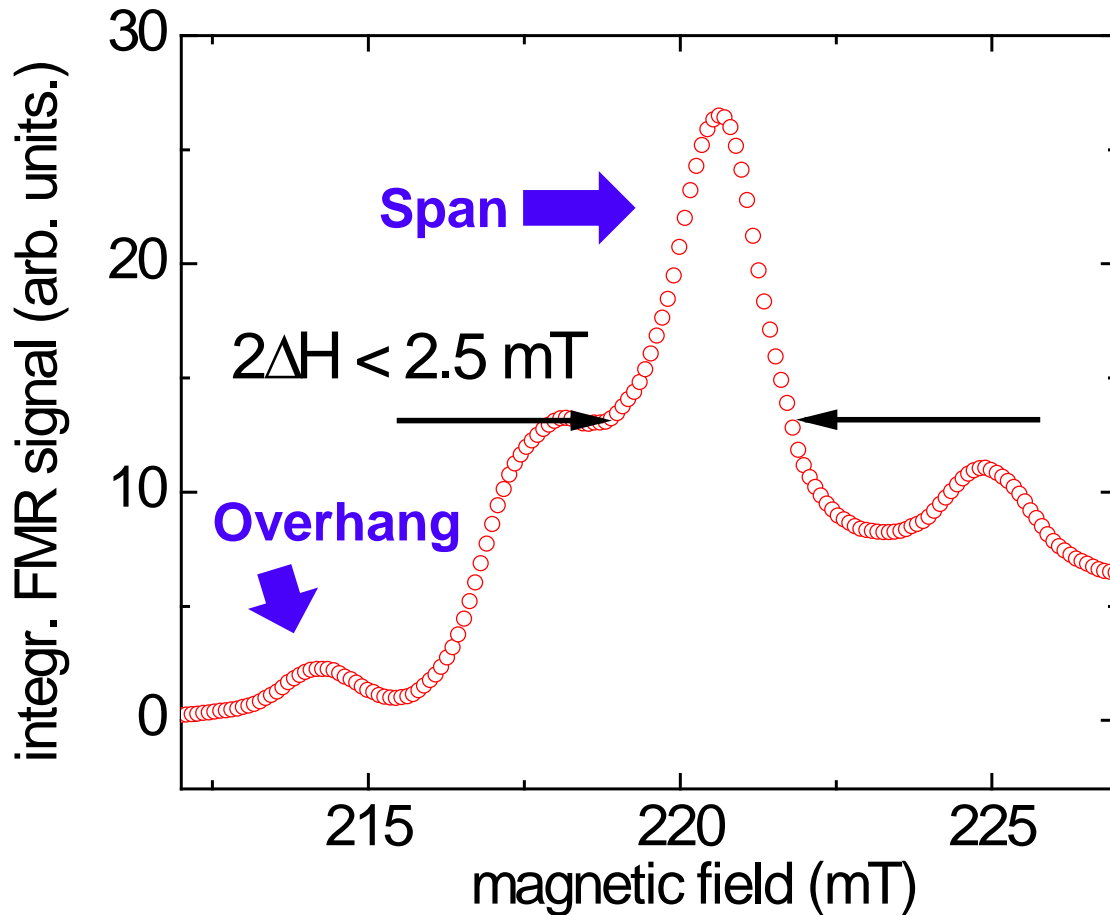
Ferromagnetic resonance

Array of bridges

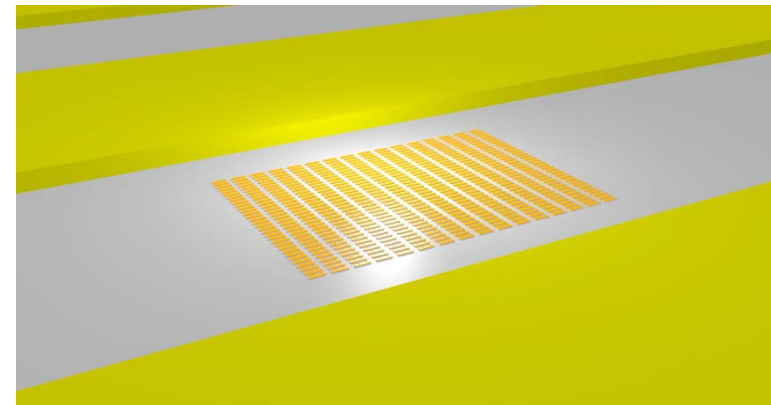
- Measurement on 8000 (nominally) identical bridges
- Linewidth of main resonance $\Delta H = 1.25 \text{ mT} @ 8 \text{ GHz}$
- Either very similar bridges or very narrow lines



Nanostructured
Materials



(F. Heyroth, GS et al.
cond-mat.1802.03176)



Scanning TR MOKE

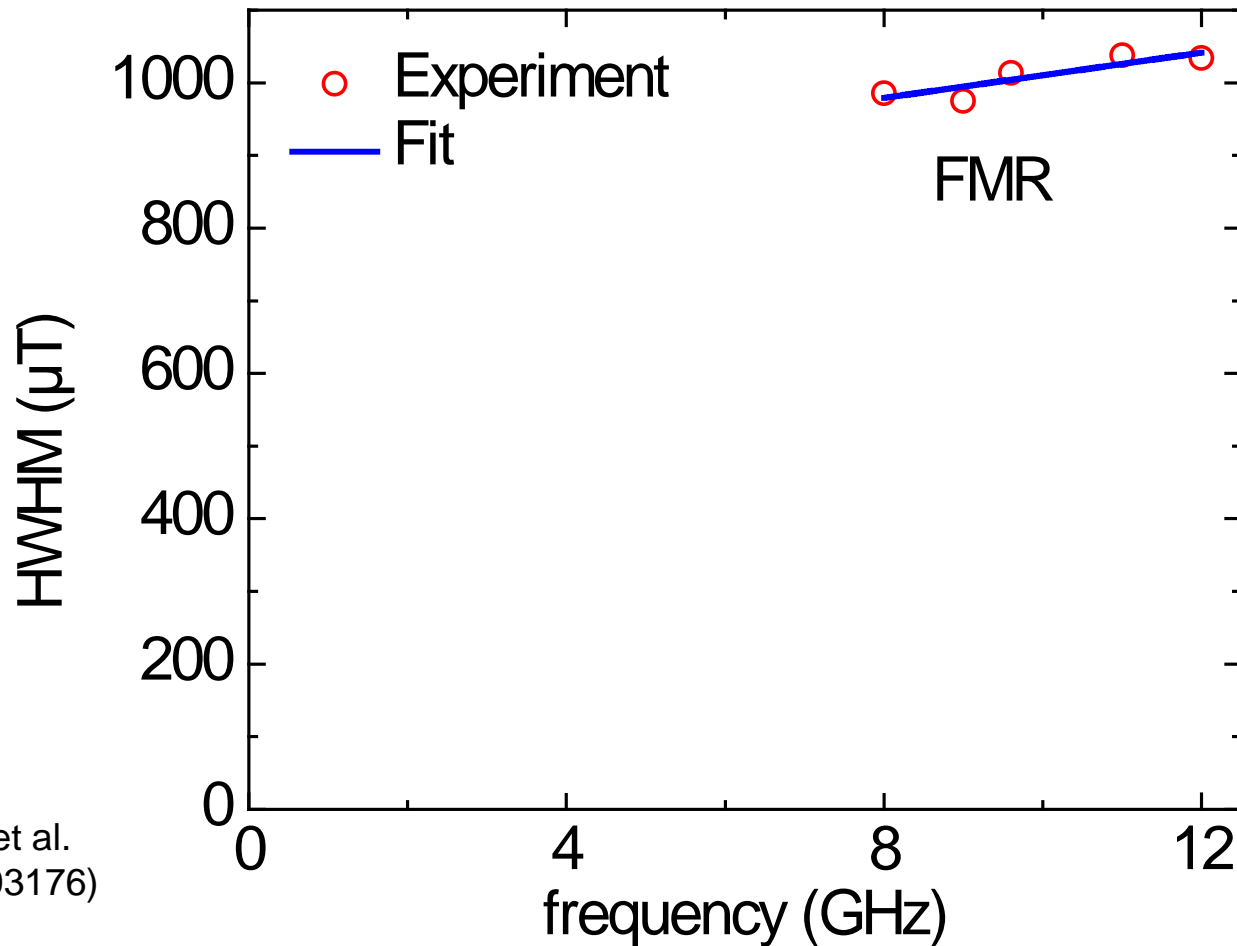
Damping



Nanostructured
Materials



- For single spot Gilbert damping $\alpha \leq 2.4 \times 10^{-4}$
- Intrinsic linewidth at zero field: $\Delta H = 75 \mu\text{T}$
- Really high quality thin film YIG



(F. Heyroth, GS et al.
cond-mat.1802.03176)



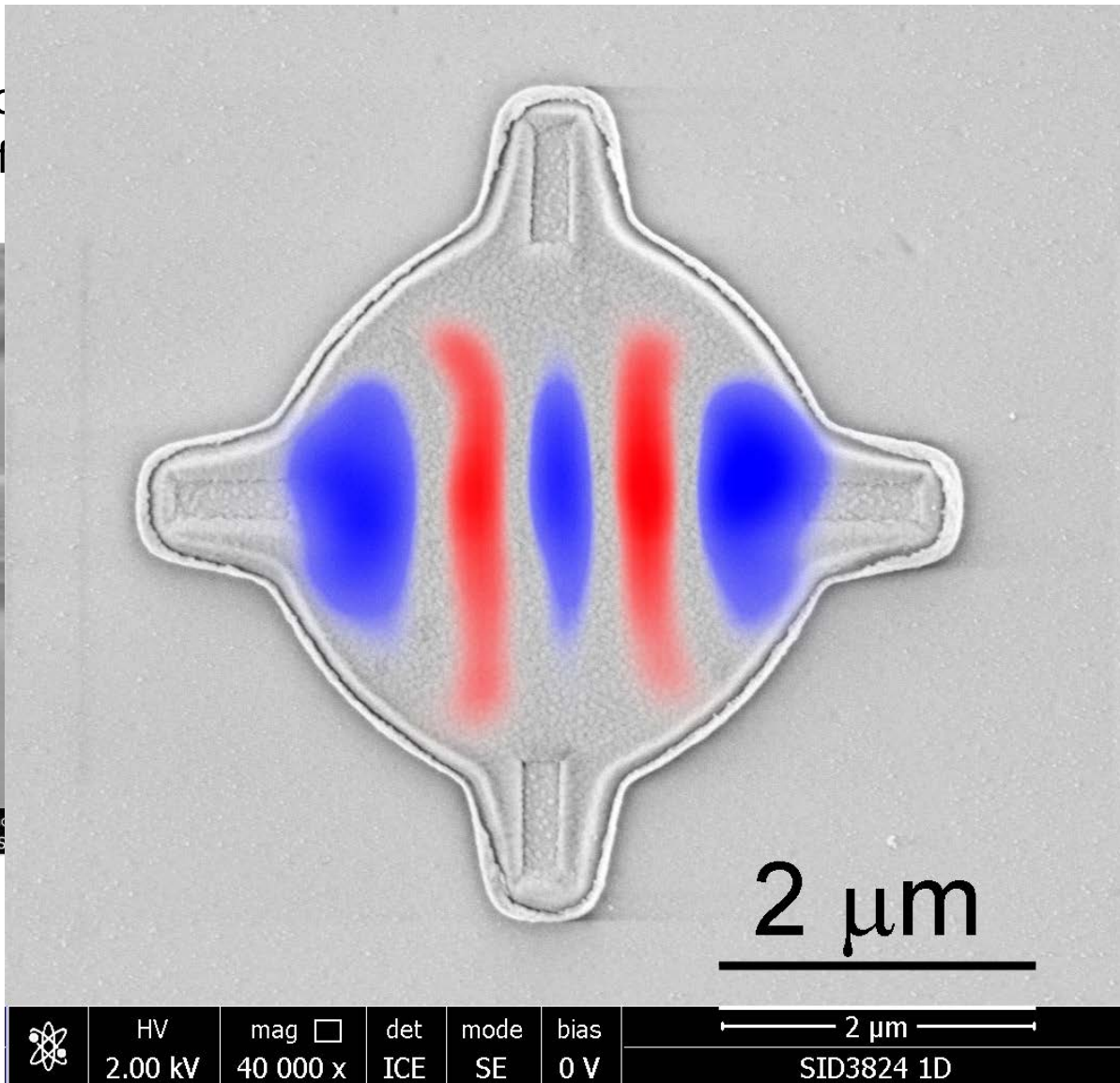
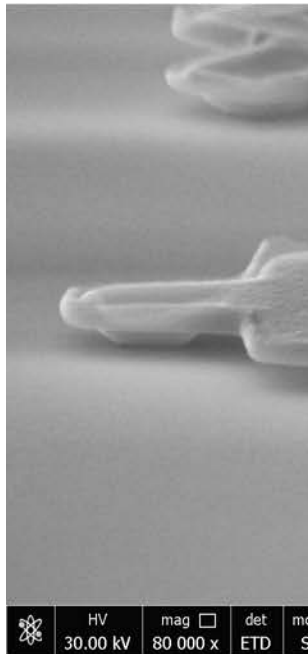
Different shapes



Nanostructured
Materials

- Allo
- Diff

sible

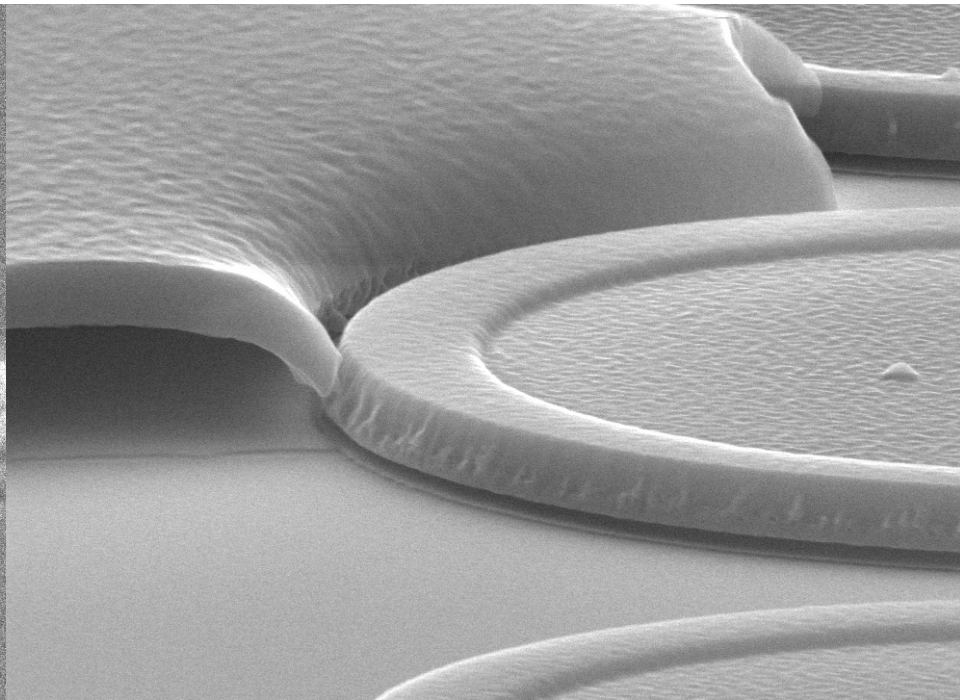
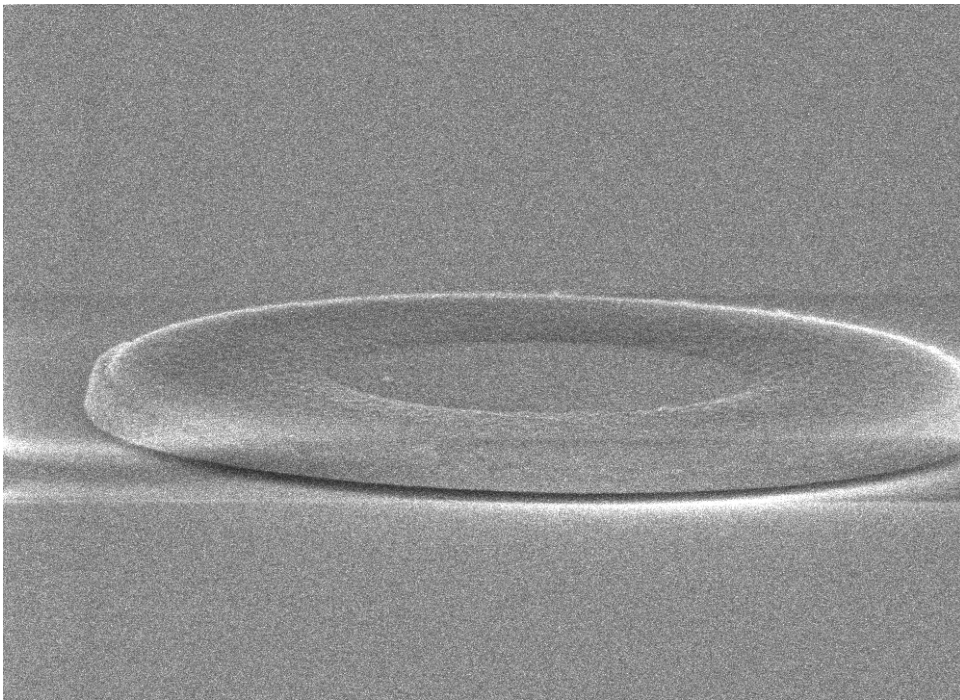
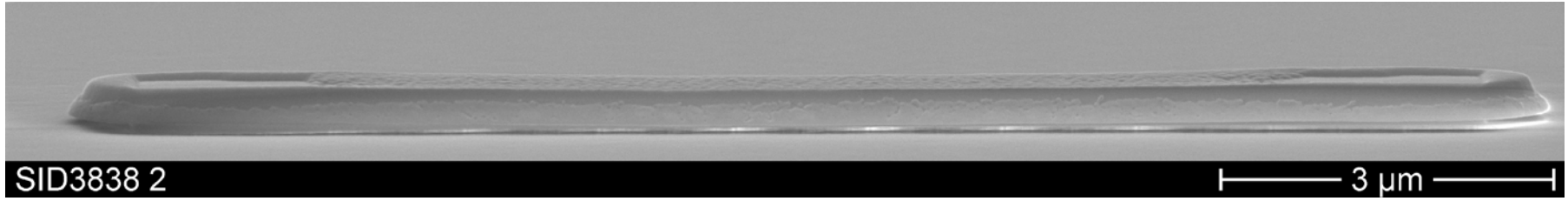


A few more

Optimized process



Nanostructured
Materials



Conclusion



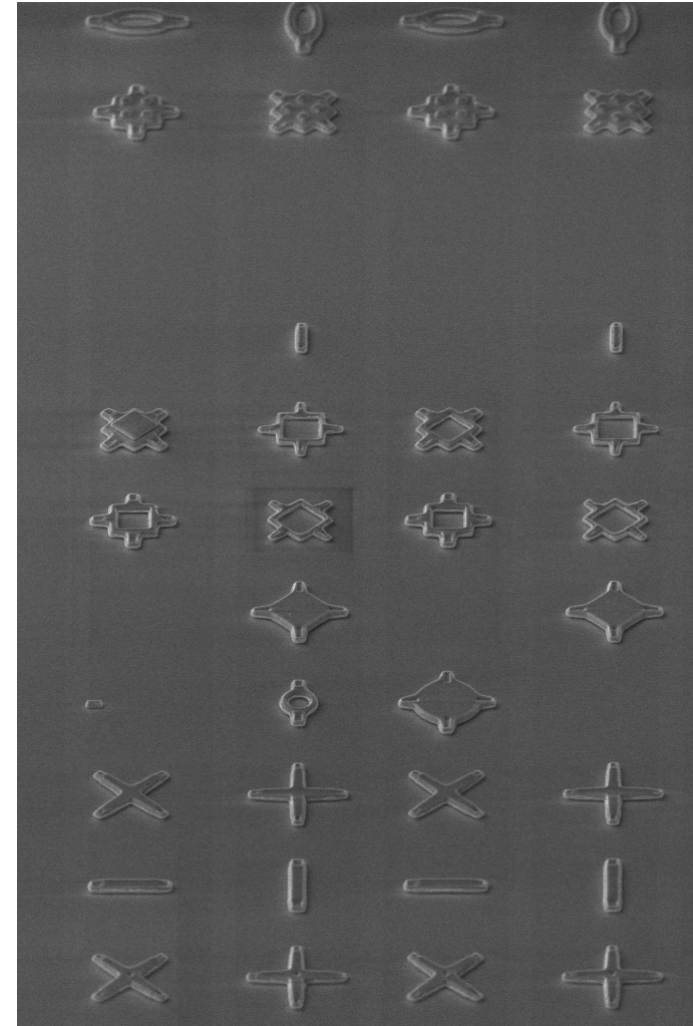
Nanostructured
Materials

Results

- New process allows the fabrication of nano-sized free standing YIG resonators
- Span is monocrystalline with single defect
- Crystal structure adopted from substrate
- Resonators can accommodate magnons with **low damping and narrow linewidth**
- Additive process compatible with post processing and addition of more microelectronics (waveguides, magnets, etc.)

Outlook

- Coupling to mechanical vibrations must be investigated
- Ultimately coupling to qubits / integration of multiple devices
- Collaborations welcome!



Jobs



Nanostructured
Materials

PhD positions

- Ultrafast spintronics:
 - Electrical detection of GMR in the 100 GHz regime
 - Electrical detection of ultrafast demagnetization (sub 10 ps)
- YIG Spin Hall nano-oscillators
 - Fabrication and nanopatterning
 - Characterization in the GHz regime